

MICROSCOPE UNITS AND OBJECTIVES (UV, NUV, VISIBLE & NIR REGION)

Optical Measuring



Mitutoyo can offer a wide range of microscope units and objective lenses based on our proprietary optical technologies and precision processing technologies cultivated over many years.

Used by customers around the world for a wide variety of applications.

Applications

- Production of semiconductors, electronics, liquid crystals, etc.
- Optical systems for quality control systems and experimental research equipment.
- Built-in optical units for visual inspection systems.
- Observation of microorganisms and other moving objects.

* We also accept custom orders for products not listed in this catalog, so please feel free to contact us for more information.



Ref.: "Microbio-World Ver.7,"
> (http://elfe.miyakyo-u.ac.jp/opac/2008/03/cd_2.html)

Optical Measuring Applications

Optical Inspection With Wide Field of View



Lineup supporting various observation methods, including bright-field, dark-field, polarizing, differential interference, near infrared, high resolution, etc. Inspection process can be streamlined with wide field of view model.

White Light Interference Analysis



Compact design realizes non-contact high-accuracy fine surface shape analysis through white light interference.
⇒ 3D shape measurement

*The following are application examples within Japan.

Auto-Focus Microscope Units



- AF added to microscope units embedded in equipment
- High-speed AF realized for minuscule parts and flat faces

Compact Raman Microscope Units



- Raman systems now available for our NIR optical systems
- Applicable to material analysis

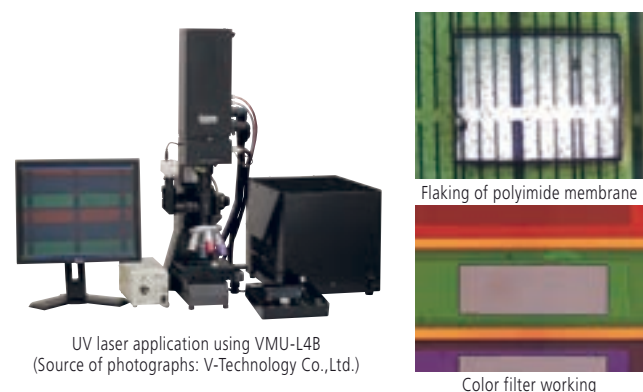
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You can download the CAD data, spectral transmission characteristics, and focal point on the image side data for each product.

For details, please check our website.
<https://www2.mitutoyo.co.jp/eng/products/gazoukogaku/lens.html>

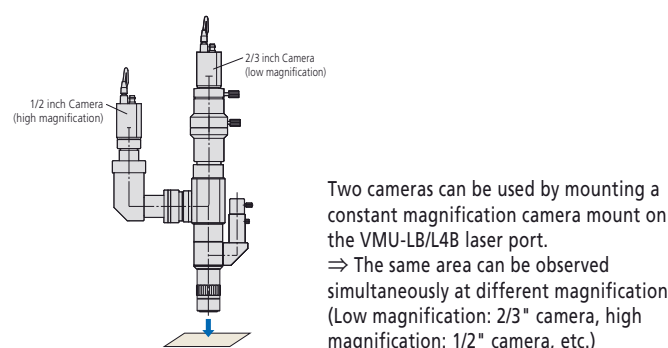
Laser Fine Machining



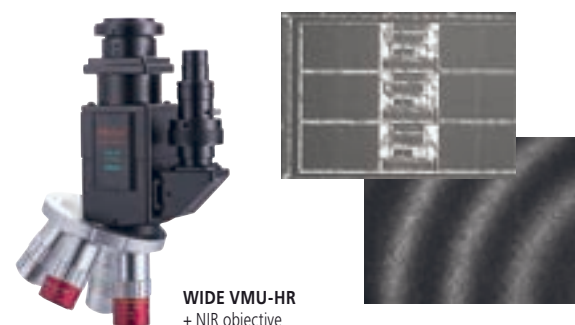
Objectives compatible with YAG lasers (1064 nm, 532 nm, 355 nm and 266 nm) allow high precision and quality working.

- > Removal of protective films/organic films, etc
- > Cutting of IC wiring (Au, Al) and exposure of lower layer pattern
- > Fine photomask and FPD repair, etc

High/Low Magnification Microscope (Dual-Camera)



IR Analysis/Inspection



Infrared analysis inspection is possible in combination with a microscope unit supporting NIR series objective lenses.

- > Transmission analysis of silicon materials
- > Non-destructive evaluation of MEMS interiors
- > Internal observation of semiconductor packages (IC)/wafer junction void evaluation
- > Infrared spectral characteristics analysis, etc

All-Focused Image Generation



Ultra-high-speed focus range variation from low- to high-magnification lens, no mechanical vertical drive for focused images, arbitrary cross-section image acquisition possible.
*For details, see the No. 14025 TAGLENS catalog

Microscope Unit for Incorporating in Equipment
VMU



Features

- > Ultra-small and lightweight
- > Wide-field image (Approx. 4 times as much as VMU-V)

Features

- > Small and lightweight
 - > Compatible with near-infrared optical systems(transmission)*1
- *A near-infrared source and suitable camera is required.

Features

- > Can be used with YAG (UV-NUV-VIS-NIR) lasers.
 - > Enhanced rigidity and improved performance
 - > Equipped with a dual camera, the same area can be observed*
- *Use together with the fixed-magnification monitoring camera mount (No.378-087)

Specifications

Model		VMU-S	VMU-V	VMU-H	VMU-LB	VMU-L4B	
Code No.		378-404	378-505	378-506	378-513	378-514	
Camera Mounting Orientation		Vertical		Horizontal	Vertical (rotatable)		
Observation		Bright-field/Erect image		Bright-field/Inverted image	Bright-field/Erect image		
Optical Tube	Camera Port	Optical Features	Magnification: 1X; Wavelength (λ): visible radiation				
		Mount	C-mount (centering and parfocal adjustment)			C-mount with centering and parfocal adjustment and green filter switch	
	Tube Lens	Magnification	0.5X	1X			
		Correction Wavelength	visible	visible - NIR		NUV - visible - NIR	UV - visible - NIR
		Focal Length	100 mm	200 mm			
	Laser Port	Optical Features	—			Magnification: 1X λ: 355/532/1064 nm	Magnification: 1X λ: 266/355/532/1064 nm
		Mount				YAG laser source (fundamental, second and third harmonic mode) available	YAG laser source (fundamental and second, third and fourth harmonic mode) available
						With parfocal adjustment	
Polarizer Unit *1		—	Available for observation		Available for observation and laser applications		
Suitable Objective (Required)	For Observation	M Plan Apo, M Plan Apo SL, G Plan Apo *2	M Plan Apo, M Plan Apo HR (50X, 100X), M Plan Apo SL, G Plan Apo				
			NIR series				
	For Laser Cutting	—			NIR series, NUV series	NIR series, NUV series, UV series	
	For White Light Interference Measurement	WLI Plan Apo series	—				
Applicable Camera		2/3-inch or smaller CCD camera (C-mount specification)					
Optical System Epi-Illumination		Telecentric with aperture diaphragm					
Illuminated Lens Tube		Bright-field/LED adapter (Standard accessory)	Bright-field/Fiber adapter (Standard accessory) /LED adapter (optional) No.02AVB662				
Illumination Unit (Optional)		LED light source *3	Fiber illumination unit (LED) (No.176-386)				
Main Unit Mass		400 g	650 g	750 g	1270 g	1300 g	

*1: M Plan Apo 1X objective should be used together with a polarizer (No.378-710 or 378-715) as flaring may occur depending on the object being observed.
*2: Use together with screw conversion adapter (RMS⇒W26) No.02AZG975
*3: Please check the installation dimensions (p.8) when attaching.
Note : Observe the following precautions when using VMU-LB or L4B with YAG laser source attached.
1. Be aware of the laser power and energy density. Otherwise, the optical system may be damaged.
2. Check the mass of the laser source. When mounting on a high-speed device or acceleration/deceleration device, please contact us.

See video from here.
<https://bcove.video/3Kp07QU>



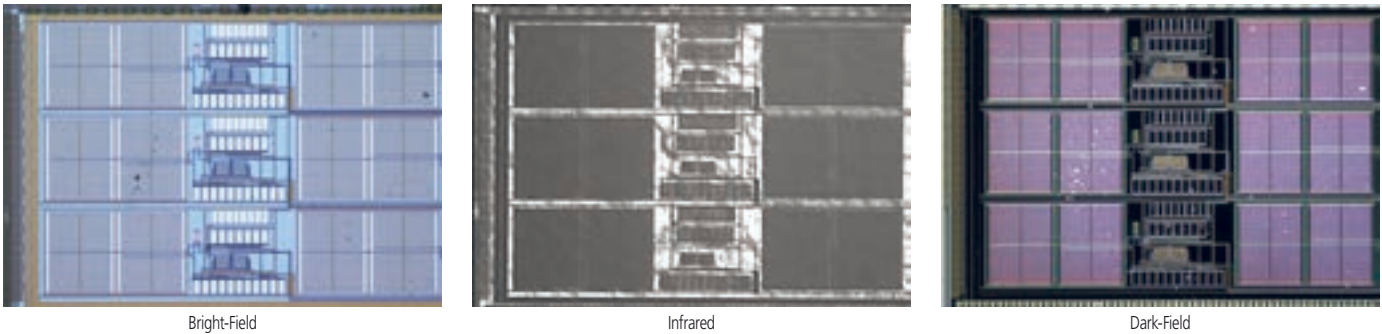
Features

- > Observation over a wide field of view (Image field of ø30 mm)
- > Compatible with HR series of high resolving power lens (Designed with pupil diameter of ø16.8)
- > Greatly enhanced brightness on the periphery of the field of view (Reduces the dependence on the light distribution characteristics.)
- > Compatible with near-infrared optical systems (transmission)*1
- > Small design (Refer to page 9 for the dimensions.)

*1: *A near-infrared light source and compatible camera are required separately.

Features

- > Observation over a wide field of view (Image field of ø30 mm)
- > Supports dark-field observation suited to inspection for foreign objects and scratches (Instantaneous switching between bright-field and dark-field is possible with illumination light source on/off)
- > Small design (WIDE VMU-BD)



Specifications

			For Bright-Field Observation		For Bright/Dark-Field Observation			
Model			WIDE VMU-HR		WIDE VMU-BD* ¹	WIDE VMU-BDV	WIDE VMU-BDH	
Code No.			378-519		—	378-517	378-518	
Camera Mounting Orientation			Vertical		Vertical		Horizontal	
Observation			Bright-field/Erect image			Bright/Dark-field/Erect image	Bright/Dark-field/Inverted image	
Optical Tube	Camera Port	Optical Features	Magnification: 1X Visible light - Near-infrared light			Magnification: 1X Visible light		
		Mount						
	F-Mount, C-Mount (with aligning and parfocal adjustment mechanism)							
	Imaging Forming (Tube) Lens		Built in 1X (visible - NIR)			Built in 1X (visible)		
	Image Field		ø30 mm					
Polarized Unit * ²		Mountable						
Objective Lens (Required)			M Plan Apo, M Plan Apo HR, M Plan Apo SL, G Plan Apo, NIR series			BD Plan Apo		
Applicable Camera			Diagonal line length: 30 mm or less (equivalent to APS-C format)					
Optical System Epi-Illumination			Telecentric (Pupil diameter of ø16.8 with aperture diaphragm)			Telecentric illumination, Bright/Dark-field illumination optical tube (Dual-port fiber-optic illumination) Bright/Dark-field switching with light source on-off		
Illuminated Lens Tube			Bright-field illuminated lens tube (rotatable) * ³ LED adapter and fiber adapter included as standard			Bright-field illuminated lens tube (rotatable) * ³ Fiber adapter included as standard		
Illumination Unit (Optional)			Fiber illumination unit (LED) (No.176-386)					
Main Unit Mass			1400 g			1600 g	2000 g	2150 g

*1: Made-to-order products *2: Polarized light observation is possible with brightfield illumination. *3: The fiber (light source) mount orientation can be changed.

Diagram of Fiber Mount (VMU) showing dimensions and compatibility:

- Adapter for Mitutoyo fiber-optic cable
- Dimensions: 19, 12, 10, (2)
- Compatibility: $\phi 14^{+0.1}_{-0.05}$ (Compatible with third-party fiber-optic cables)
- Compatibility: $\phi 10^{+0.1}_{-0.05}$ (Compatible with Mitutoyo fiber-optic cable)
- Fiber-optic cable end position $\phi 8.2$ (Fiber effective diameter of $\phi 5$ or greater)

Technical drawings of the mounting plate showing front and side views with dimensions and screw specifications.

Front View Dimensions:

- Total width: 61
- Distance from left edge to centerline: 45
- Distance from centerline to right edge: 38
- Total height: 109
- Distance from bottom edge to centerline: 17.5
- Distance from bottom edge to top of mounting holes: 24
- Distance from centerline to mounting holes: 29
- Distance from bottom edge to mounting holes: 46
- Distance from centerline to mounting holes (opposite side): 29
- Distance from bottom edge to mounting holes (opposite side): 104
- Distance from bottom edge to mounting holes (opposite side): 19.5

Side View Dimensions:

- Distance from top edge to centerline: 38
- Distance from centerline to right edge: 3
- Distance from top edge to mounting holes: 14
- Distance from centerline to mounting holes: 28
- Distance from top edge to mounting holes (opposite side): 51

Screw Specifications:

- 4-M4x0.7 screw holes, depth 8 (equal numbers of holes at the same positions on the opposite side)

Technical drawing of the VMU-V camera showing front and side views with dimensions.

Front View Dimensions:

- Top width: 59.5
- Top width (inner): 43.5
- Top width (mount): 6.5
- Left height: 17.5
- Left height (total): 152.5
- Left height (total): 247.5
- Left height (bottom): 95 (Parfocalizing distance)
- Bottom width: 20.5
- Bottom width (total): 106
- Internal width: 50
- Internal height: 27
- Internal height (total): 76

Labels:

- Intermediate image position
- C mount
- 6-M4x0.7 screw holes, depth 6 (equal numbers of holes at the same positions on the opposite side)
- Fiber-optic cable mounting position
- Objective (optional)

Side View Dimensions:

- Top width: 3
- Top width (total): 47
- Bottom diameter: $\varnothing 43$

Label:

- (Emblem)

Technical drawing of the C-mount adapter showing front, side, and rear views with dimensions and labels.

Dimensions:

- Front view: 113.5 (total height), 89.5 (height to top of C-mount), 17.5 (height of C-mount), 80.5 (width), 63 (width of C-mount), 59.5 (width of main body), 43.5 (width of main body), 6.5 (width of fiber-optic cable mounting position).
- Side view: 106 (height), 76 (height to top of C-mount), 20.5 (height of C-mount), 27 (width of C-mount), 27 (width of main body), 3 (width of fiber-optic cable mounting position), 47 (width of main body), 47 (width of main body).
- Rear view: 113.5 (total height), 89.5 (height to top of C-mount), 17.5 (height of C-mount), 80.5 (width), 63 (width of C-mount), 59.5 (width of main body), 43.5 (width of main body), 6.5 (width of fiber-optic cable mounting position).

Labels:

- C mount
- Intermediate image position
- Objective (optional)
- 6-M4x0.7 screw holes, depth 6 (equal numbers of holes at the same positions on the opposite side)
- Fiber-optic cable mounting position
- (Emblem)

[illegible]

Technical drawing of the F-mount adapter, showing front and side views with dimensions and labels.

Front View Dimensions (mm):

- Top flange diameter: 32
- Top flange thickness: 60
- Top flange offset: 70.5
- Top flange to image position: 146.5
- Image position diameter: 64
- Image position offset: 27
- Image position to fiber mounting position (BF): 164.2
- Fiber mounting position (BF) diameter: 27
- Fiber mounting position (BF) to fiber mounting position (DF): 164.2
- Fiber mounting position (DF) diameter: 27
- Fiber mounting position (DF) to bottom flange: 95.5
- Bottom flange diameter: 50
- Bottom flange thickness: 188.5
- Bottom flange to workpiece surface: 95
- Workpiece surface to objective mount: 283.5
- Objective mount diameter: 27
- Objective mount to objective (optional): 95
- Objective (optional) diameter: 27
- Objective (optional) to workpiece surface: 95

Side View Dimensions (mm):

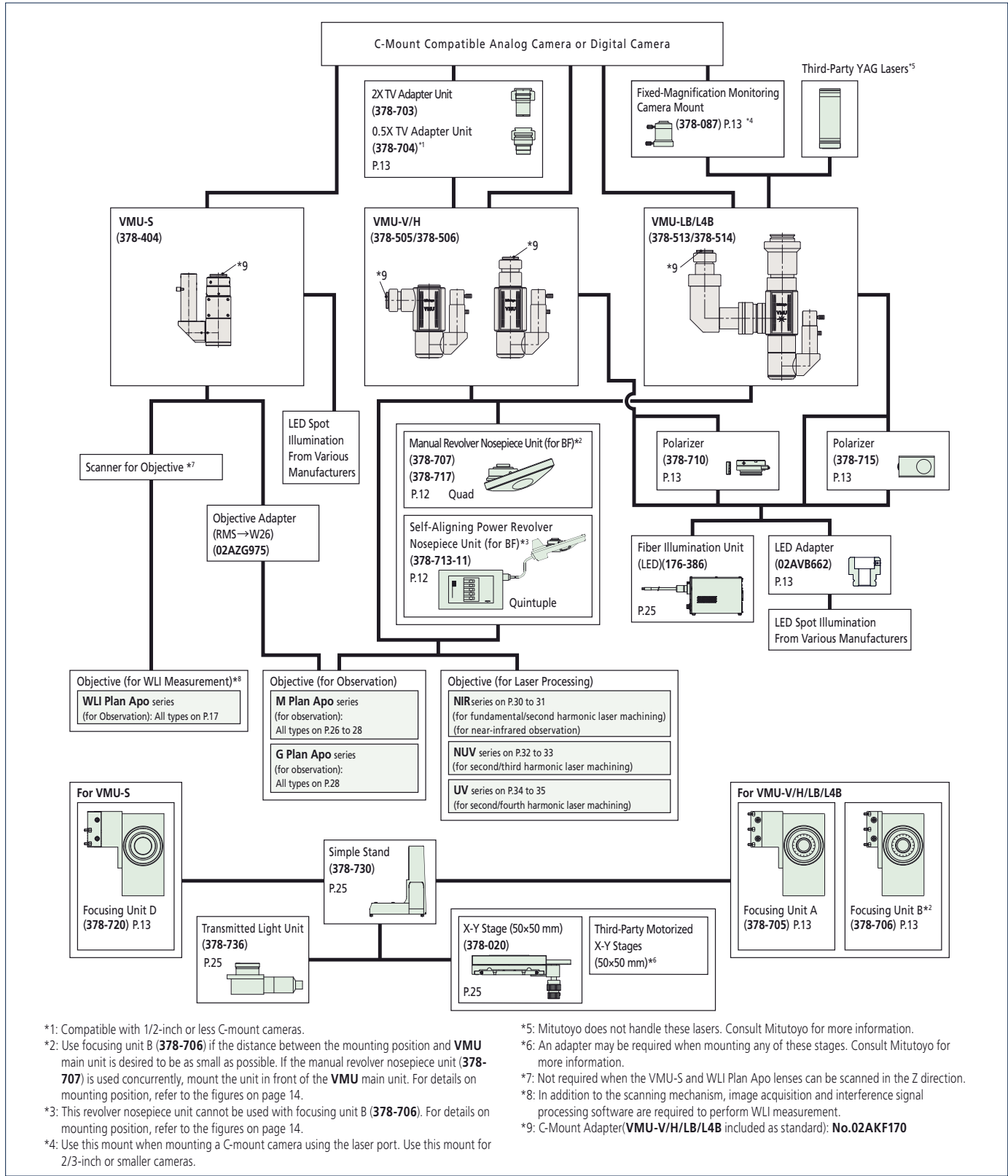
- Top flange diameter: 64
- Top flange thickness: 27
- Top flange to workpiece surface: 85
- Workpiece surface to objective mount: 283.5
- Objective mount diameter: 27
- Objective mount to objective (optional): 95
- Objective (optional) diameter: 27
- Objective (optional) to workpiece surface: 95

Labels:

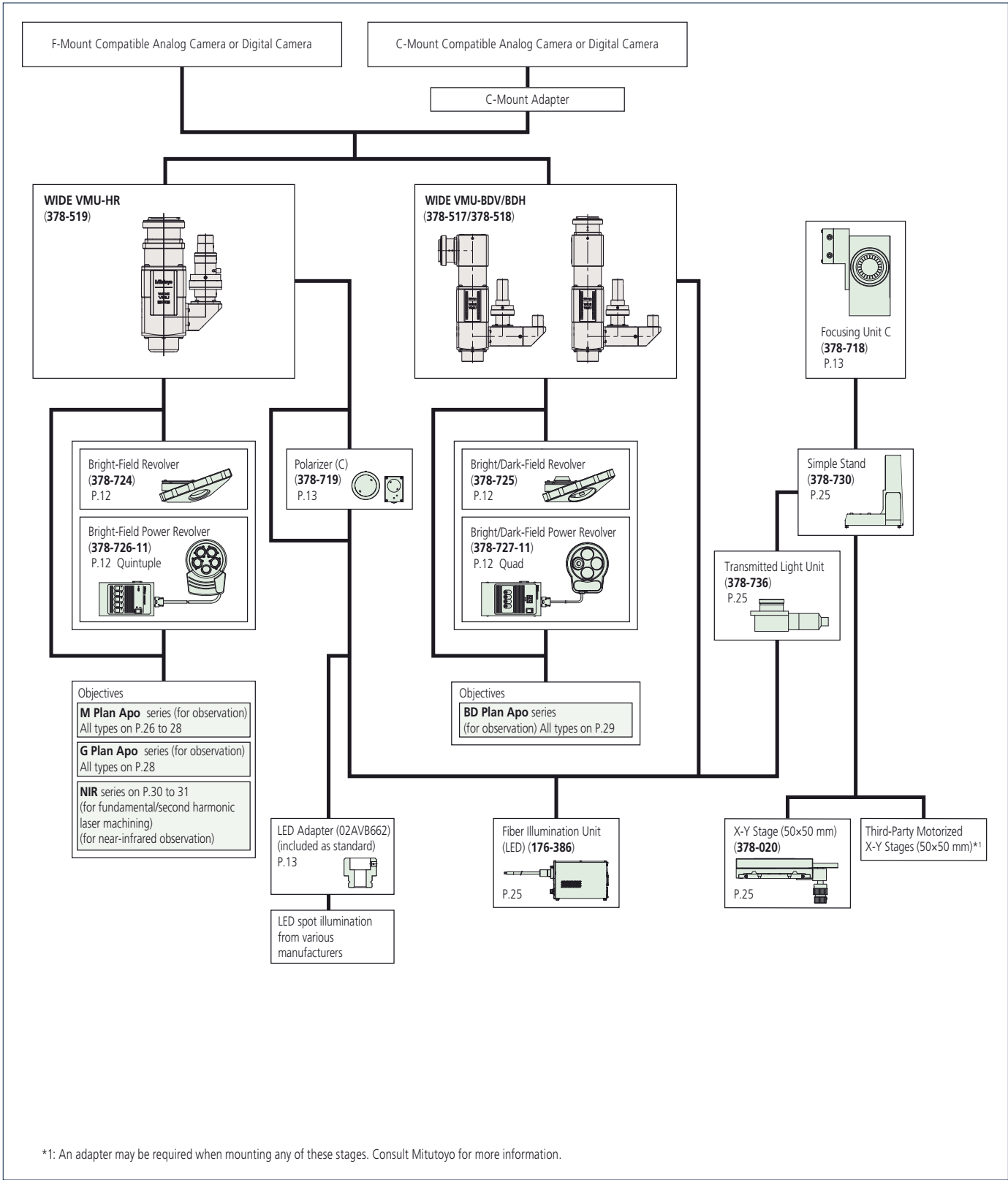
- F mount
- Image position
- 4-M4x0.7 depth 6 (Same position and number on other side)
- Fiber mounting position (BF)
- Fiber mounting position (DF)
- 4-M4x0.7 screw holes, depth 6
- Objective mount
- Objective (optional)
- Workpiece surface

VMU System Diagram

VMU



WIDE VMU



Optional Accessories for VMU

Manual Revolver

Up to 4 objective lenses can be mounted.



No.378-724



No.378-725



Installed on 378-717 VMU-V



Installed on 378-724 WIDE VMU-HR

*Objectives shown mounted on tubes are optional.

Model	Bright-Field Revolver			Bright/Dark-Field Revolver
Code No.	378-707	378-717	378-724	378-725
Observation Method	Bright-field		Bright-field	Bright/Dark-field
No. of Objective Mounts	4 (Reference hole)	4 (1 reference hole and 3 holes with centering and parfocal adjustment)	4 (Reference hole)	4 (Reference hole)
Mass	780 g	990 g	825 g	755 g
Applicable Models	VMU-V, VMU-H, VMU-LB, VMU-L4B		WIDE VMU-HR	WIDE VMU-BDV WIDE VMU-BDH

Power Revolver

Up to 5 objective lenses can be mounted on the bright-field power revolver.

Up to 4 objective lenses can be mounted on the bright/dark-field power revolver.



No.378-726-11



No.378-727-11



Installed on No.378-713-11 VMU-V



Installed on No.378-726-11 WIDE VMU-HR

*Objectives shown mounted on tubes are optional.

Model	Bright-Field Power Revolver		Bright/Dark-Field Power Revolver
Code No.	378-713-11	378-726-11	378-727-11
Observation method	Bright-field		Bright/Dark-field
No. of Objective Mounts	5 (1 reference hole and 4 holes with centering adjustment)		4 (Reference hole)
View Field Adjustment	±0.5 mm		-
Positioning Accuracy	2 σ = 3 μm		-
Durability (Life-Time)	1 million repositioning operations		-
Drive Method	DC motor		-
Power Supply	AC100 V - 240 V Max. power consumption is approx. 10 W		AC100 V - 240 V Max. power consumption is approx. 6 W
Output Interface*1	RS-232C*1 for external PC control		
Cable Length	2.9 m*2 (connection of power revolver and console box)		
Dimensions (WxHxD) and Mass	Revolver: 130x47x186 mm,1.8 kg, Console box: 108x63x176 mm,810 g		Revolver: 164x65x137 mm,1.8 kg, Console box: 108x72x193 mm,810 g
Applicable Models	VMU-V, VMU-H, VMU-LB, VMU-L4B		WIDE VMU-HR WIDE VMU-BDV, WIDE VMU-BDH

*1: Optional RS-232C Cable: 12AAA807

*2: The length of cable connecting the power revolver and console box is a safe maximum and therefore Mitutoyo does not guarantee error-free operation if a cable extension is used to increase total cable length.

Focusing Unit

For manual focusing. With A and C mounted on a simple stand, the stand stage center and optical axis match.



Focusing Unit A mounted on VMU-V



Focusing Unit C mounted on WIDE VMU-HR

*Objectives shown mounted on tubes are optional.

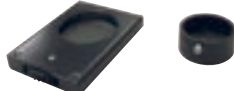
Model	Focusing Unit A	Focusing Unit B	Focusing Unit C	Focusing Unit D
Code No.	378-705	378-706	378-718	378-720
Travel Range	50 mm			
Coarse/Fine Feed	Coarse: 3.8 mm/rev., Fine: 0.1 mm/rev.			
Loading Capacity	Approx. 17.4 kg	Approx. 17.7 kg		Approx. 17.4 kg
Mass	2.9 kg	2.7 kg		2.9 kg
Applicable Models	VMU-V, VMU-H, VMU-LB, VMU-L4B		WIDE VMU-HR, WIDE VMU-BDV, WIDE VMU-BDH	VMU-S

Polarizer and Analyzer

Provides simplified polarized light observation. Also enhances contrast of low-magnification objectives.



No.378-710



No.378-715



No.378-719

Model	Polarizer and Analyzer		Polarizer and Analyzer (C)
Code No.	378-710	378-715	378-719
Applicable Models	VMU-V, VMU-H	VMU-LB, VMU-L4B	WIDE VMU-HR, WIDE VMU-BDV, WIDE VMU-BDH

TV Adapter Unit

C-mount adapters for changing to a higher or lower magnification.

Model	2X TV Adapter Unit	0.5X TV Adapter Unit
Code No.	378-703	378-704
Magnification	2X	0.5X
Suitable Camera	2/3 inch or smaller type	1/2 inch or smaller type
Mass	Approx. 25 g	
Applicable Models	VMU-V, VMU-H	



No.378-703



No.378-704

Camera Mount

Can be attached to the laser mount (VMU-LB and VMU-L4B) for dual-camera system.

Model	Camera Mount
Code No.	378-087
Suitable Camera	2/3 inch or smaller type (C-mount)
Mass	Approx. 180 g
Applicable Models	VMU-LB, VMU-L4B

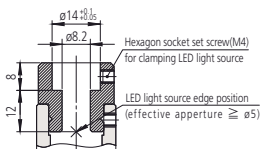


No. 378-087

LED Adapter

Model	LED Adapter
Code No.	02AVB662
Mass	Approx. 12 g
Applicable Models	VMU-V, VMU-H, VMU-LB, VMU-L4B, WIDE VMU-HR*

*For WIDE VMU-HR, standard accessory.



No. 02AVB662

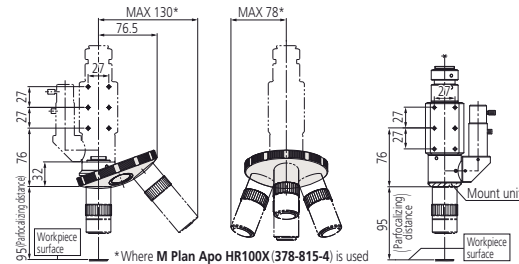
Unit: mm

Dimensions of Optional Accessories for VMU

Unit: mm

Manual Revolver

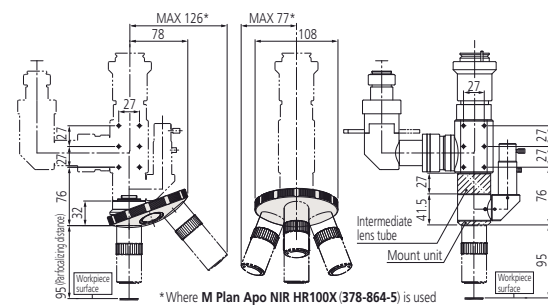
Bright-Field Revolver (378-707/378-717)



When mounting the revolver on **VMU-V** or **VMU-H**

Note 1: The lens mount must be removed from VMU.

Note 2: The orientation of the revolver can be freely set to the mounting surface.



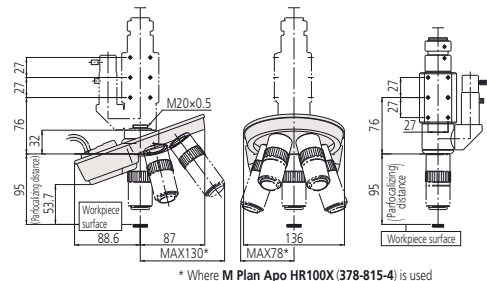
When mounting the revolver on **VMU-LB** or **VMU-L4B**

Note 1: The middle optical tube and lens mount must be removed from VMU.

Note 2: The orientation of the revolver can be freely set to the mounting surface.

Power Revolver

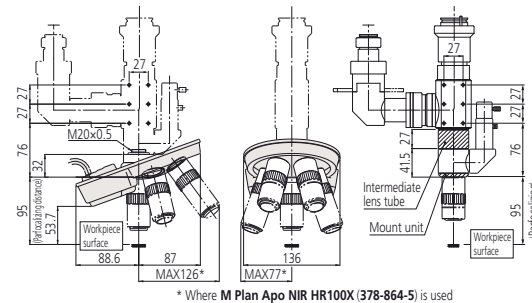
Bright-Field Power Revolver (378-713-11)



When mounting the revolver on **VMU-V** or **VMU-H**

Note 1: The lens mount must be removed from VMU.

Note 2: The orientation of the revolver can be freely set to the mounting surface.

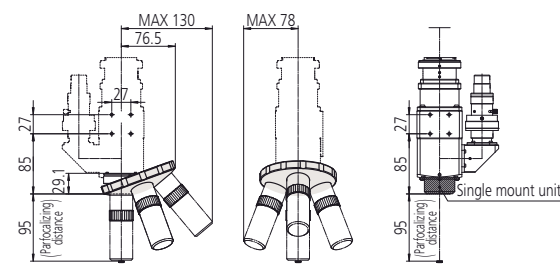


When mounting the revolver on **VMU-LB** or **VMU-L4B**

Note 1: The middle optical tube and lens mount must be removed from VMU.

Note 2: The orientation of the revolver can be freely set to the mounting surface.

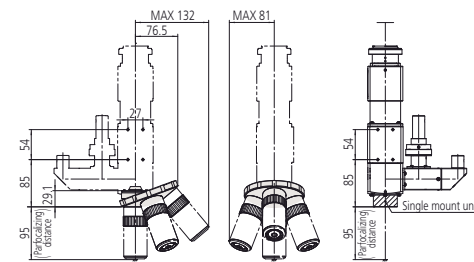
Bright-Field Revolver (378-724)



Note 1: Revolver is installed by removing the single mount unit, but the distance between the mounting position of WIDE VMU main unit and the stage is unchanged.

Note 2: Revolver mounting direction is limited to the direction indicated in the above figure.

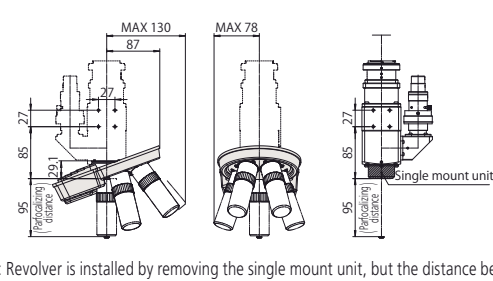
Bright/Dark-Field Revolver (378-725)



Note 1: Revolver is installed by removing the single mount unit, but the distance between the mounting position of WIDE VMU main unit and the stage is unchanged.

Note 2: Revolver mounting direction is limited to the direction indicated in the above figure.

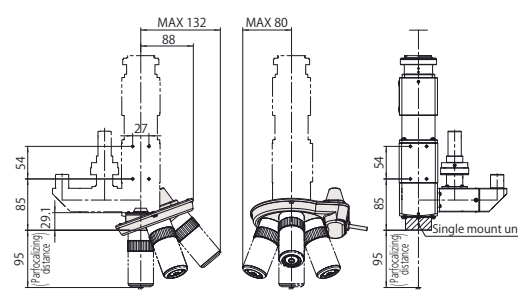
Bright-Field Power Revolver (378-726-11)



Note 1: Revolver is installed by removing the single mount unit, but the distance between the mounting position of WIDE VMU main unit and the stage is unchanged.

Note 2: Revolver mounting direction is limited to the direction indicated in the above figure.

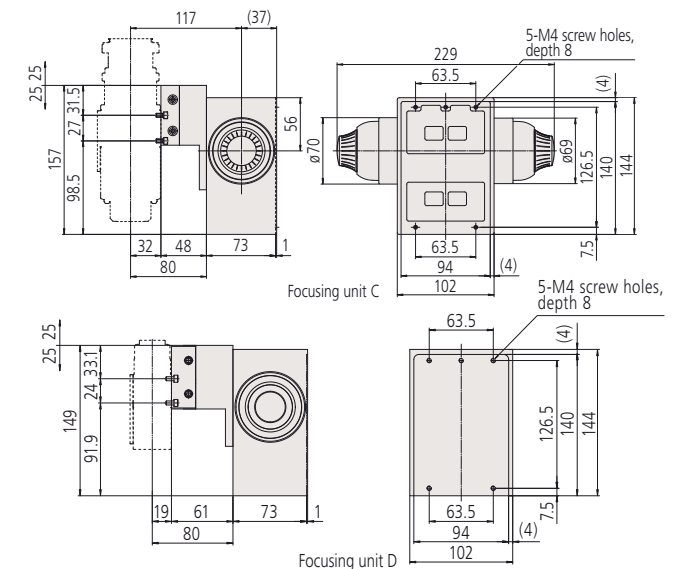
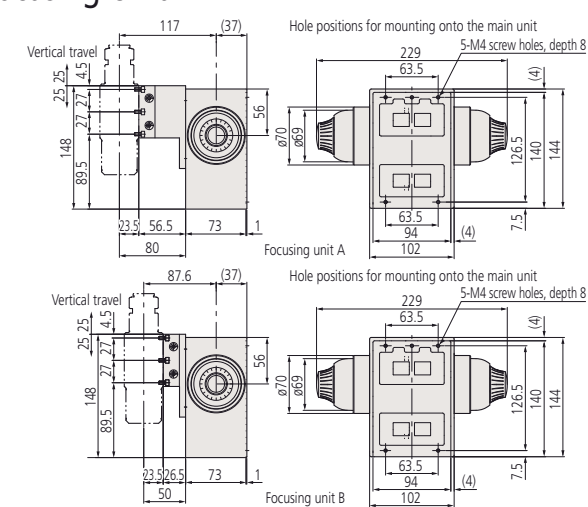
Bright/Dark-Field Power Revolver (378-727-11)



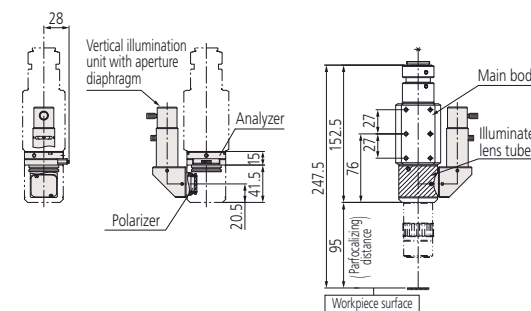
Note 1: Revolver is installed by removing the single mount unit, but the distance between the mounting position of WIDE VMU main unit and the stage is unchanged.

Note 2: Revolver mounting direction is limited to the direction indicated in the above figure.

Focusing Unit



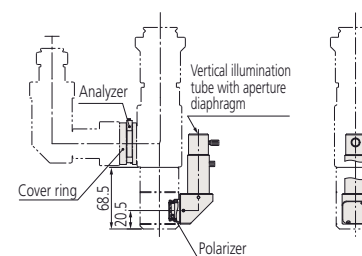
Polarizer and Analyzer



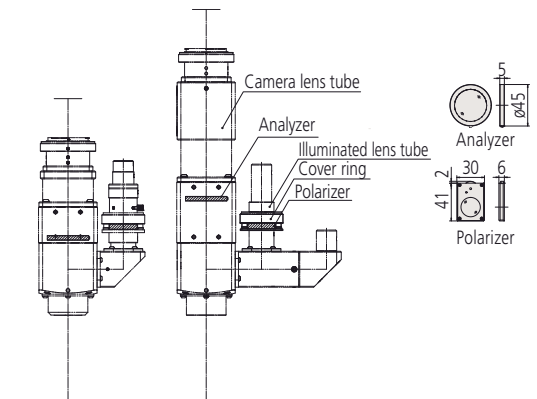
Installing the polarizer and analyzer on **VMU-V** or **VMU-H**

Note: The analyzer is installed by removing the illuminated lens tube.

The polarizer is installed by removing the vertical illumination unit with aperture diaphragm.



Polarizer and Analyzer (C)



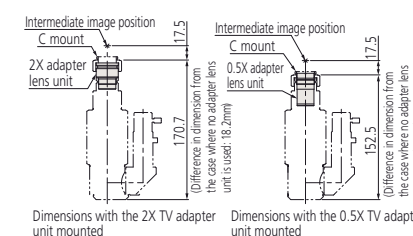
Note: The polarizer is installed by loosening the cover ring.
The analyzer is installed by removing the camera lens tube.

When installing the polarizer on **VMU-LB** or **VMU-L4B**

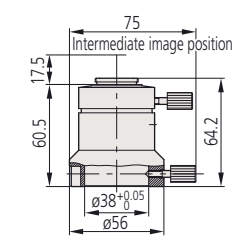
Note: The analyzer is installed by loosening the cover ring.

The polarizer is installed by removing the vertical illumination unit with aperture diaphragm.

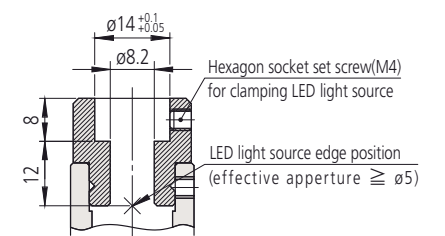
TV Adapter Unit



Camera Mount



LED Adapter



White Light Interference Optical Unit
WLI-Unit



* Objectives shown mounted on tubes are optional.

Features

- > **Non-contact high-accuracy fine surface texture measurement is possible through white light interference*:** 3D shape measurement.
- > **Height measurement accuracy not dependent on optical magnification**
Measurement enabled with high Z-resolution even with low-magnification lens
- > **High aspect ratio measurement**
Supports high aspect ratio shape measurement through detection not dependent on optical-based NA
- > **High robustness with regard to disturbance vibration**
- > **Compact and lightweight**
* The results may be affected by the shape and surface texture of the object being observed.



Specifications

Code No.		554-001	554-002	554-003
Model		WLI-Unit-003	WLI-Unit-005	WLI-Unit-010
WLI-Unit Sensor Head	Cable length (m)	3	5	10
	Applicable objective lens *Optional selection	WLI Plan Apo series		
	Tube lens magnification	1X		
	Focal range (f mm)	100		
	Scanning mechanism	Mitutoyo Objective Lens Scanner		
	Size/Weight	108x68x191 mm / 1.7 kg		
WLI Measurement (WLI-Unit-003/005/010 Common)	Z motion range	8000 μm		
	Measurement mode	High throughput	Standard	High resolution
	WLI measurement Z range	2100 μm	1900 μm	1700 μm
	Throughput @20 μm range	3.0 s	4.0 s	6.0 s
	Z resolution	—	0.1 nm*	
	Z repeatability (σ)	—	3 nm*	
WLI-Unit Controller	I/F	WLI-Unit sensor head terminal/stop connector/GigaBit Ethernet: 2 ch		
	Rated voltage	AC100~240 V / 50, 60 Hz		
	Max. power consumption	20 W		
	Size/Weight	196x180x108 mm / 2.3 kg		
Software	WLIPAK	WLI-Unit control library (SDK), sample code, WLIPAK Sample GUI		
	WLI-Unit Calibration SW	Pixel calibration		
	Analysis software (recommended option)	MCubeMap		
Other	Frame grabber/PC	Matrox frame grabber/PC separate		

*Representative values in our measurement environment

Recommended PC Specifications

OS: Windows 10 Pro 64 bit/Windows 11 Pro 64 bit, CPU: Xeon Processor 8 Core (2.0 GHz or above), memory: 8 GB or above, storage: 25 GB or above, optical drive: DVD-ROM drive (for software installation), communication port: RJ-45 × 1 port (EtherNET), extension slots: PCI Express 3.0 × 8 or above

Objective Lens for White Light Interference Measurement
WLI Plan Apo

WLI-Unit

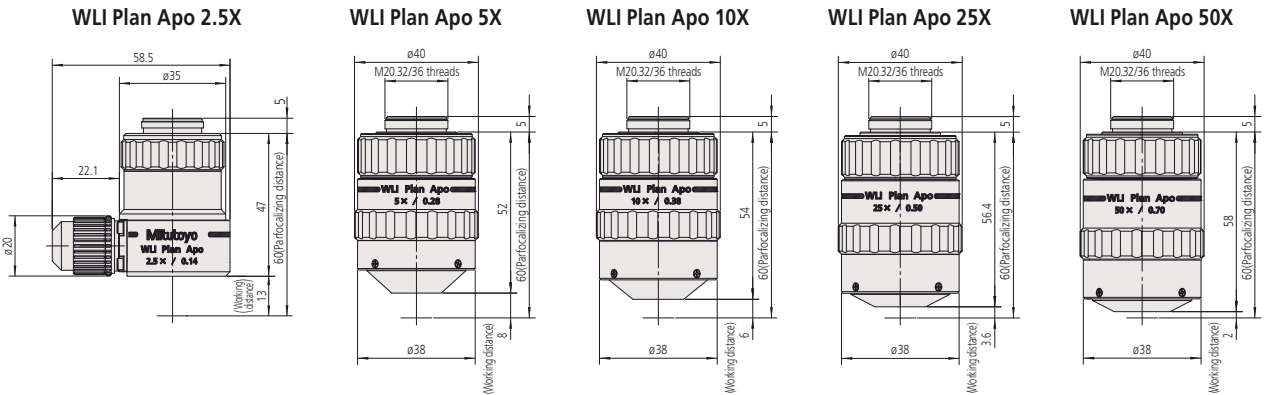


Features

- > New design matching the WLI-Unit
- > Ensures long working distance while more compact and lightweight (parfocal 60 mm)
- > High NA, high resolution
- > Plan Apochromat
- > Interference fringe adjustment mechanism equipped as standard

Dimensions

Unit: mm



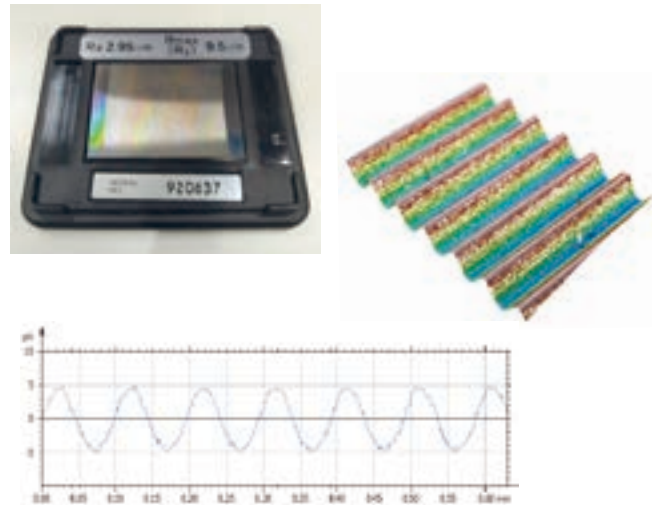
Lens Specifications

Model	Code No.	N.A.	W.D. (mm)	f (mm)	R (μm)	Parfocalizing Distance (mm)	FOV (mm)		Applicable Tube Lens f (mm)	Mirror Tube Length (Excluding Mounting Screws)	Outermost Diameter	Mounting screws	Mass (g)
							WLI-Unit	2/3 Inch Camera					
WLI Plan Apo													
WLI Plan Apo 2.5X	378-400	0.14	13.0	40	2.0	60	2.94×2.25	2.64×3.52	100	47	36.4 (excluding interference unit) 58.5 (Max)	RMS / 20.32 mm ×36 TP	320
WLI Plan Apo 5X	378-005	0.28	8.0	20	0.98	60	1.46×1.12	1.32×1.76	100	52	40		210
WLI Plan Apo 10X	378-401	0.38	6.0	10	0.72	60	0.73×0.56	0.66×0.88	100	54	40		220
WLI Plan Apo 25X	378-402	0.50	3.6	4	0.55	60	0.29×0.22	0.26×0.35	100	57	40		290
WLI Plan Apo 50X	378-403	0.70	2.0	2	0.39	60	0.14×0.11	0.13×0.18	100	58	40		300

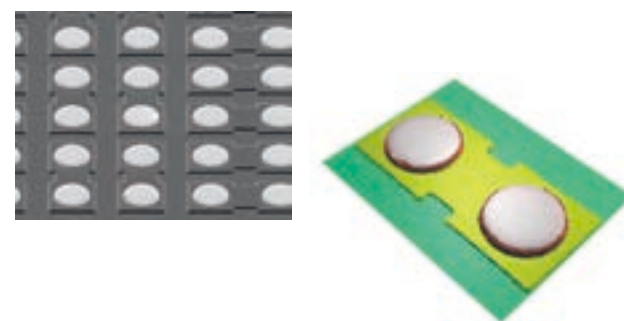
- Resolution values in the specifications above are calculated based on reference wavelength (λ = 0.55 μm).
- Magnification when used in combination with a Tube lens (focal length 100 mm)

WLI Measurement Example

Roughness Specimen 3 μm

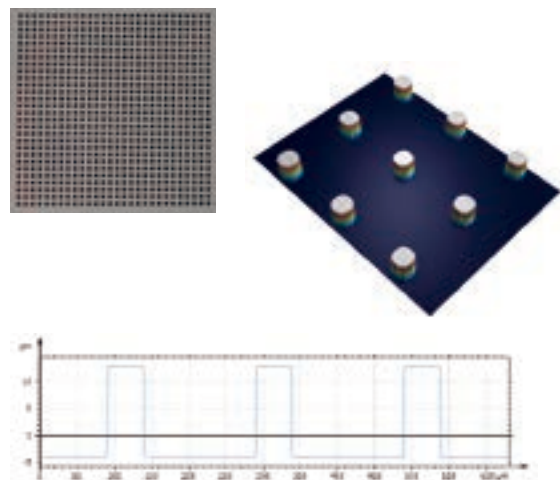


Semiconductor Test Pattern (TEG)

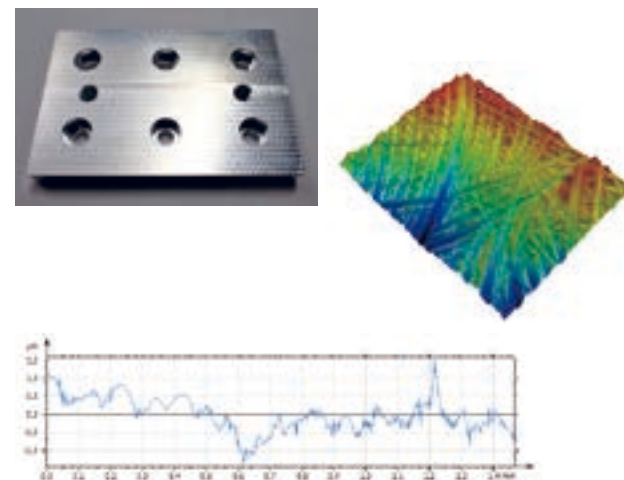


Provided by Walts Co., Ltd. and ASK INDEX

Cu Pattern (Glass Substrate)

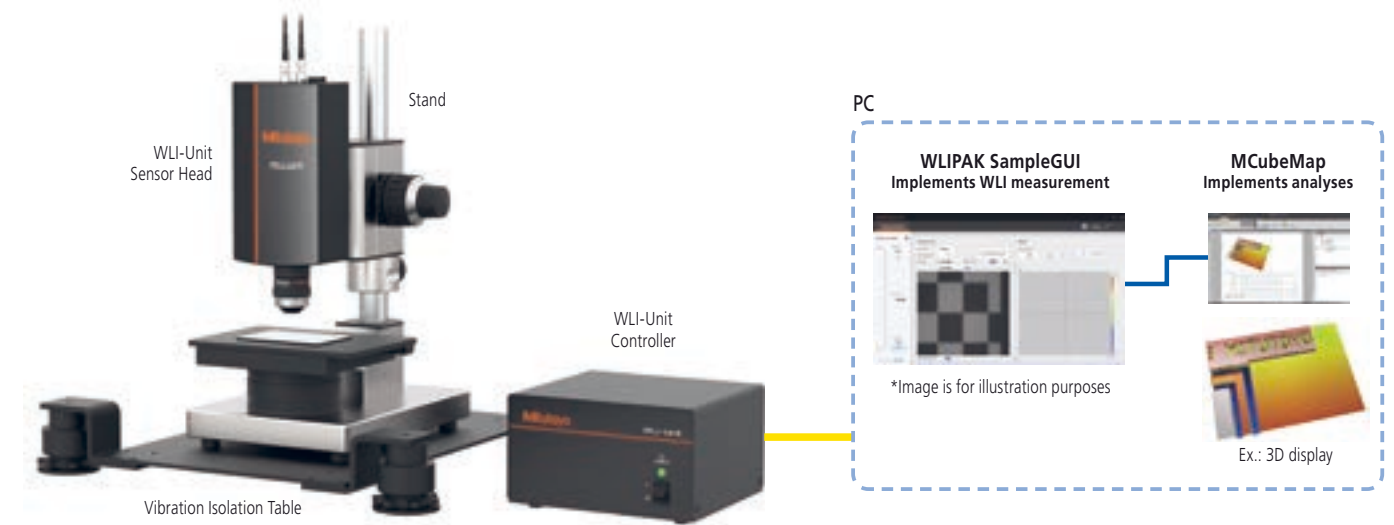


Metal Machined Surface (Aluminum)



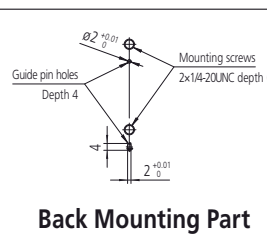
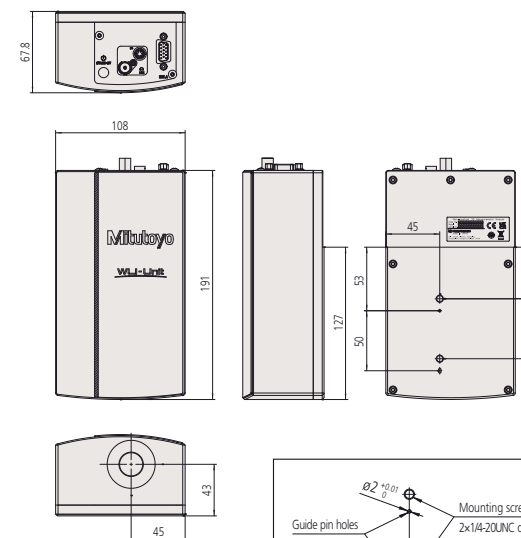
WLI System Configuration

(System Example With Stand/Manual Stage/Vibration Isolation Table)

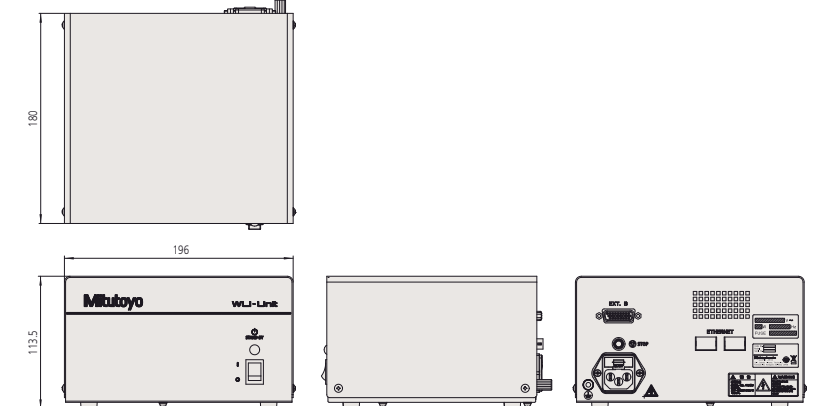


Dimensions

WLI-Unit Sensor Head



WLI-Unit Controller



Unit: mm

Microscope Unit

FS70



The eyepieces, revolver and objectives shown mounted are optional.

Features

- > Compact microscope unit with trinocular eyepiece tube

(Suitable for observation of many different types of object: metal surfaces, semiconductors, LCDs, resins, etc.)

> Can used with YAG (near-infrared, visible, near-ultraviolet, or ultraviolet) lasers.*1

(Suitable for cutting, trimming, repair and marking of IC wiring (Au, Al), removing and processing thin-films (insulating film) and repair of color filters.)

> Compatible with infrared optical systems*2
- > Product range supporting various observation methods

(Bright-field/Dark-field/Simple polarization)

> Equipped as standard with a Koehler illumination with aperture diaphragm for epi-illumination optical systems

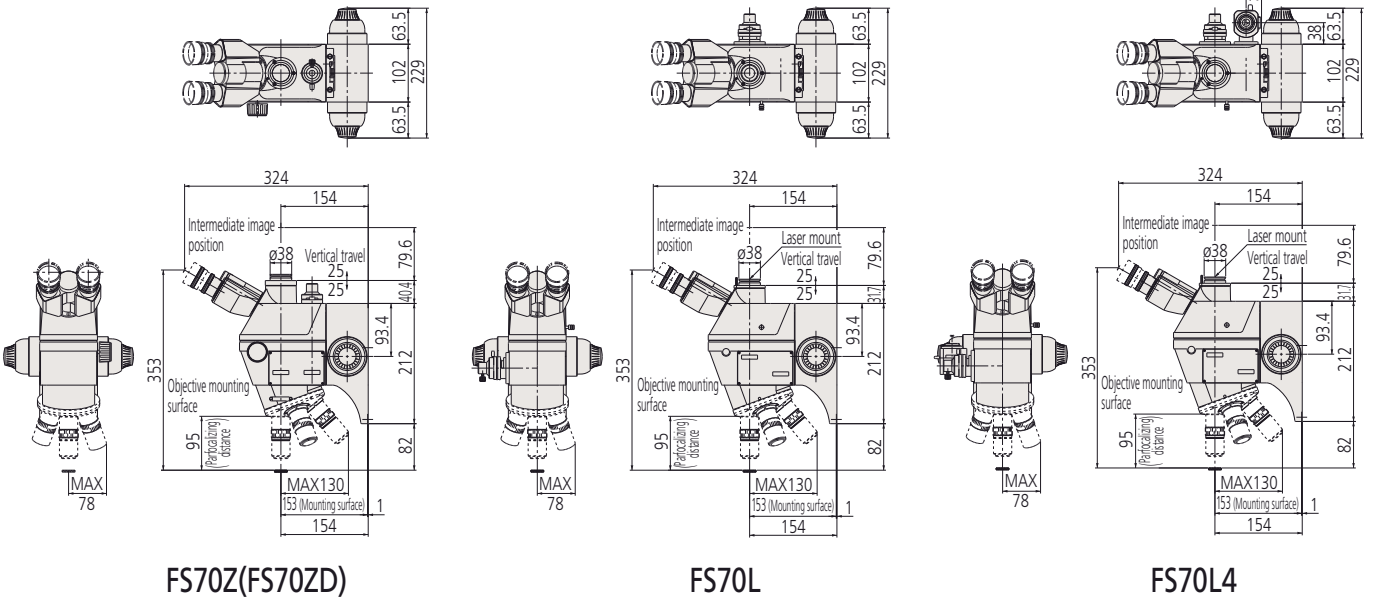
> High operability with microscopes

(Inward revolver design and long-working-distance objectives)

*1: The performance and safety of laser-equipped system products is not guaranteed.

*2: A near-infrared source and suitable camera are required.

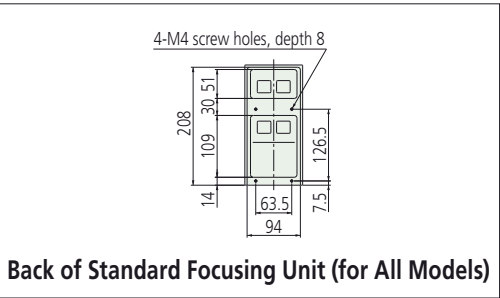
FS70 Dimensions



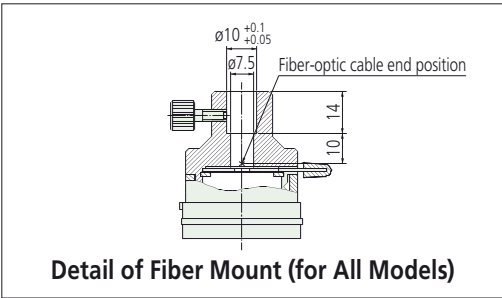
FS70Z(FS70ZD)

FS70L

FS70L4



Back of Standard Focusing Unit (for All Models)



Detail of Fiber Mount (for All Models)

Specifications

Standard Head Type	Model	FS70	—	FS70Z	—	FS70ZD	FS70L	FS70L4	
	Code No.	378-184-1	—	378-185-1	—	(Made to Order)	378-186-1	378-187-1	
Tilting Head Type	Model	—	FS70-TH	—	FS70Z-TH	FS70ZD-TH	FS70L-TH	FS70L4-TH	
	Code No.	—	378-184-3	—	378-185-3	(Made to Order)	378-186-3	378-187-3	
		Erect image							
Observation Image	BF (Bright-Field)	✓	✓	✓	✓		✓	✓	
	BD (Bright-Field/ Dark-Field)					✓			
	Polarization	✓	✓	✓	✓	✓	✓	✓	
Eyepieces (Required)		10X (field number 24) • 15X (field number 16) • 20X (field number 12)							
Optical Tube	Trinocular Tube	Field Number	24						
		Eye Width Adjustment	Siedentopf, adjustable interpupillary distance range: 51 - 76 mm						
		Tilt Angle	0 to 20° (only for -TH), displacement of eye point: approx.114 mm						
		Optical Pass Ratio	Fixed type (Eyepiece/TV = 50/50)	Switchable type (Eyepiece/Tube = 100/0: 0/100)	Fixed type (Eyepiece/TV = 50/50)	Switchable type (Eyepiece/Tube = 100/0: 0/100)	Fixed type *1 (Eyepiece/TV = 50/50)	Switchable type (Eyepiece/Tube = 100/0: 0/100)	
		Camera Port Mount	C-mount (using optional adapter B*2) Parfocal adjustment with adapter B					Use a laser with TV port.	C-mount receptacle (with green filter switch) (with parfocal adjustment)
		Protective Filter	—					Built-in laser beam filter	
	Tube Lens	1X		1X-2X zoom			1X		
	Laser Port	Optical Features					Magnification: 1X λ : 355/532/1064 nm	Magnification: 1X λ : 266/532 nm	
Mount		—				YAG laser source (fundamental, second and third harmonic mode) available	YAG laser source (second, fourth harmonic mode) available		
Microscope Head	Coarse and Fine Movement	Uniaxial coarse and fine movement (Coarse: 3.8 mm/rev. fine 0.1 mm/rev.)							
	Movement	50 mm, left and right handle							
Optical System Epi-Illumination		Epi-illumination for Bright-field (Koehler illumination, with aperture diaphragm)							
Illumination Unit (Optional)		Fiber illumination unit (LED) (No.176-386), 150 W Fiber-optic illumination unit (No.176-316) stepless adjustment, light guide length: 1500 mm							
Revolver (Required)		Self-aligning manual revolver nosepiece unit Quad / Self-aligning Power revolver nosepiece unit Quintuple				Manual revolver nosepiece unit Quad / Power revolver nosepiece unit Quad	Self-aligning manual revolver nosepiece unit Quad / Self-aligning Power revolver nosepiece unit Quintuple		
Suitable Objective (Required)	For Observation	M Plan Apo M Plan Apo HR M Plan Apo SL G Plan Apo				BD Plan Apo	M Plan Apo M Plan Apo HR M Plan Apo SL G Plan Apo		
	For Laser Cutting	—				NIR Series NUV Series *Select from wavelengths used by laser source	UV Series		
Loading*3		14.5 kg	13.6 kg	14.1 kg	13.2 kg	14.1 kg (tilting headtype: 13.2 kg)	14.2 kg (tilting headtype: 13.5 kg)	13.9 kg (tilting headtype: 13.1 kg)	
Dimensions		Refer to P.20							
Mass (Main Unit)		6.1 kg	7.1 kg	6.6 kg	7.5 kg	6.6 kg (tilting headtype: 7.5 kg)	6.4 kg (tilting head type: 7.2 kg)	6.7 kg (tilting head type: 7.5 kg)	

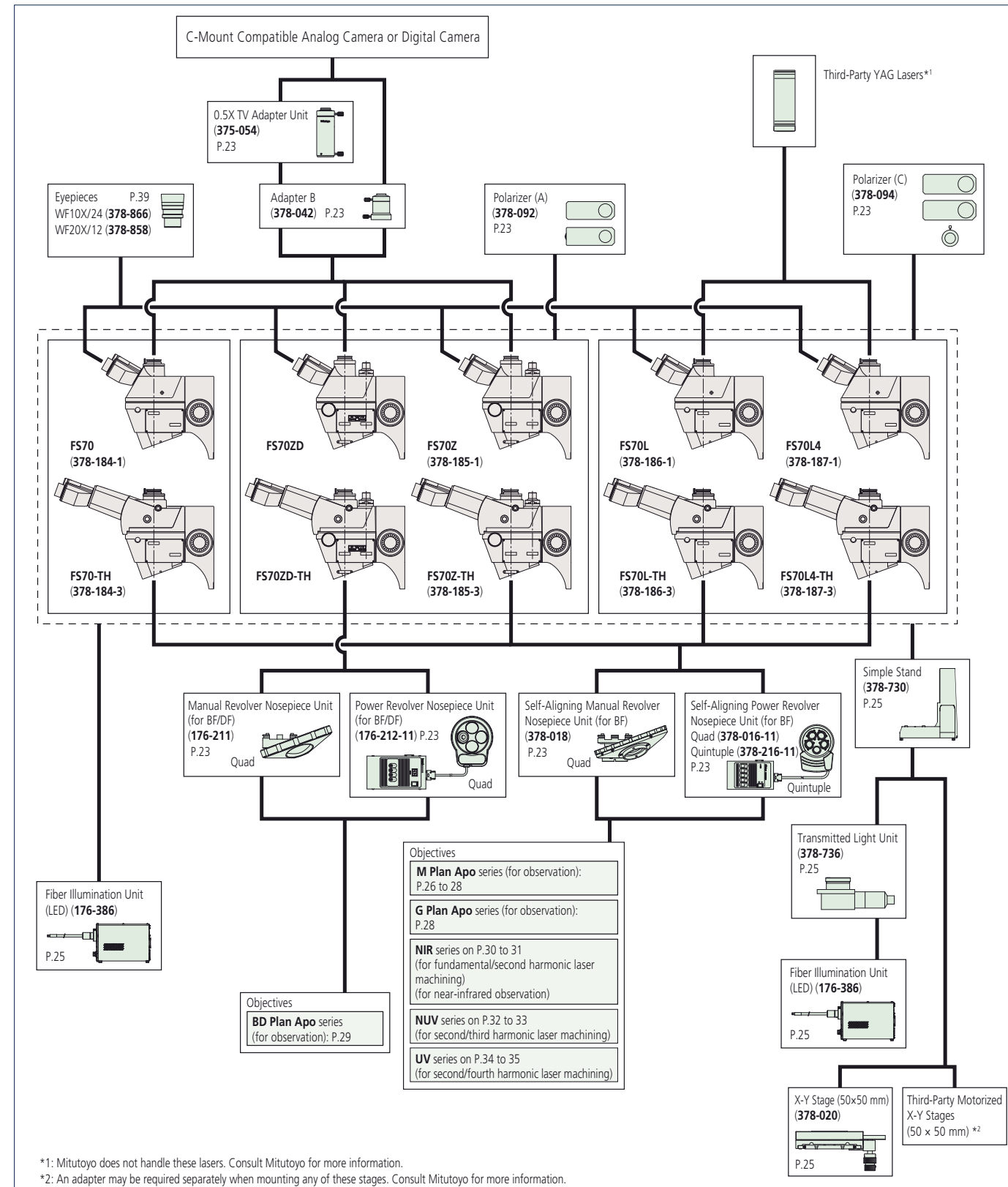
*1: It is a switchable type when using FS70ZD-TH (Tilting head type). *2: Installation is optional. *3: Loading on optical tube excluding weight of revolvers, objective lenses and eyepieces.

Note: When using the objective M Plan Apo 1X, using this lens with a differential interference contrast unit (No.378-092 or 378-094) is recommended.

Note: Observe the following precautions when using FS70L or FS70L4 with YAG laser source attached.

- Be aware of the laser power and energy density limitations of the optical system to avoid damage.
- Check the mass of the laser source. When mounting on a high-speed device or acceleration/deceleration device, please contact us.

System Diagram



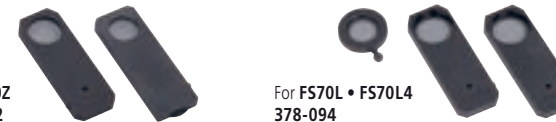
Power Revolver



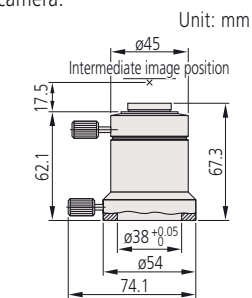
Model	Bright-Field Revolver	Bright/Dark-Field Revolver
Code No.	378-018	176-211
Observation Method	Bright-field	Bright/Dark-field
No. of Objective Mounts	4 (1 reference hole and 3 holes with centering and parfocal adjustment)	4
View Field Adjustments	±0.5 mm	—
Parfocal Adjustment	±0.5 mm	—
Mass	980 g	1.2 kg

Model	Bright-Field Revolver		Bright/Dark-Field Revolver
Code No.	378-216-11	378-016-11	176-212-11
Observation Method	Bright-field		Bright/Dark-field
No. of Objective Mounts	5 (1 reference hole and 4 holes with centering adjustment)	4 (1 reference hole and 3 holes with centering adjustment)	4
View Field Adjustment	±0.5 mm		—
Positioning Accuracy	2 σ = 3 μ m	—	—
Durability (Life-Time)	1 million repositioning operations	—	—
Drive Method	DC motor		
Power Supply	AC100 V - 240 V, 10 W	AC100 V - 240 V, 6 W	
Output Interface	RS-232C*1 for external PC control		
Cable Length	2.9 m*2 (connection of power revolver and console box)		
Dimensions (WxHxD) and Mass	Revolver: 130x47x186 mm, 1.7 kg Console box: 108x63x176 mm, 810 kg	Revolver: 164x65x137 mm, 1.4 kg Console box: 108x72x193 mm, 810 kg	

For simplified polarized-light observation. Also suitable for enhancing contrast of low-magnification objectives.

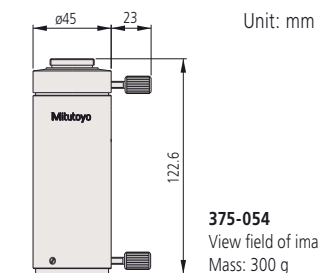


Used for mounting a C-mount camera.



378-042
View field of image: $\varnothing 11$ mm
Mass: 170 g

Allows observation over a wide field of view on the monitor (2X wide) due to the 0.5X relay optics. It is used in conjunction with the optional adapter B. A C-mount is included.



375-054
View field of image: $\varnothing 11$ mm
Mass: 300 g

*2: An adapter may be required separately when mounting any of these stages. Consult Mitutoyo for more information.

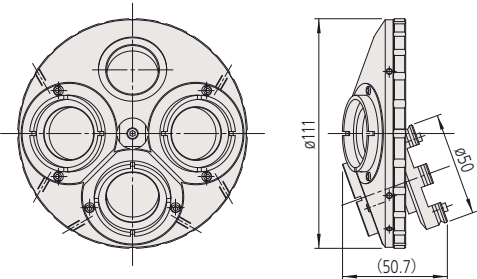
*1: Optional RS-232C Cable: **12AAA807**
 *2: The length of cable connecting the power revolver and console box is a safe maximum and therefore Mitutoyo does not guarantee error-free operation if a cable extension is used to increase total cable length.

Dimensions of Optional Accessories for FS70

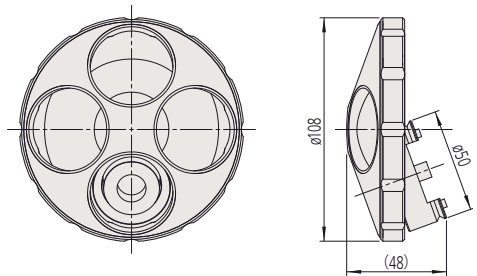
Manual Revolver

378-018

Unit: mm



176-211



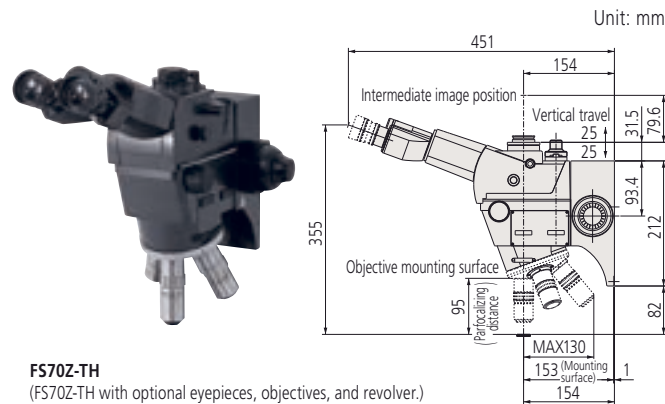
Optional Objective Adapter: 378-026-1

This objective adapter allows mounting the bright-field objective on the bright/dark-field revolver (176-211 and 176-210) while maintaining the focus position (parfocal).

Code No.	378-026-1
Applicable Models	Microscopes mounted with the bright/dark-field manual revolver or power revolver (WIDE VMU-BDV/H, MF-U, HyperMF-U)
Applicable Objective Lens	M Plan Apo, M Plan Apo SL, G Plan Apo, M Plan Apo NIR, M Plan Apo NUV, M Plan UV

Tilting Head Type

Mitutoyo's FS70-series lineup adopts a tilting head specification that allows the user to adjust the head to an appropriate eye point according to personal physical attributes when looking through the microscope eyepiece.

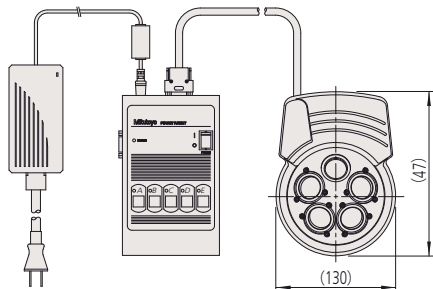


FS70Z-TH
(FS70Z-TH with optional eyepieces, objectives, and revolver.)

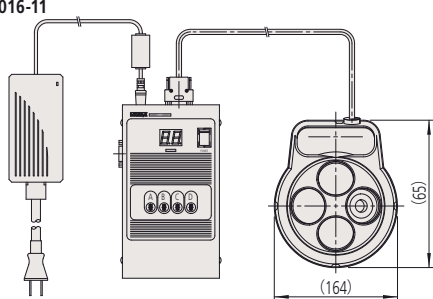
Power Revolver

378-216-11

Unit: mm



176-212-11/378-016-11

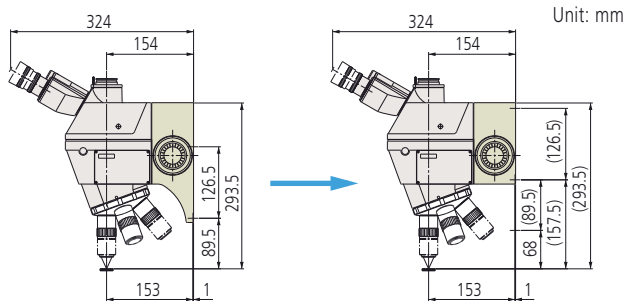


Focus Point Adjust Shim Set

Code No.	Use	Details
378-089	For bright-field revolver	The focus point adjust shim set includes 50 μm, 30 μm and 20 μm thickness SUS rings
378-090	For bright/dark-field revolver	

Short Focusing Unit Type

Manual Focusing Unit S can be mounted on the main unit 68mm higher than the standard focusing unit without changing the eye-point position. The order numbers in the following table represent the FS70-series main units on which this focusing unit has previously been mounted.



Model	FS70-S	FS70Z-S	FS70L-S	FS70L4-S
Code No.	378-184-2	378-185-2	378-186-2	378-187-2
Travel Range	50 mm			
Coarse/Fine Feed	Coarse feed: 3.8 mm/rev., Fine feed: 0.1 mm/rev.			
Loading Capacity of Camera Mount*	14.5 kg	14.1 kg	14.2 kg	13.9 kg
Mass	6.1 kg	6.6 kg	6.4 kg	6.7 kg

*Mass of revolver, objective, and eyepiece are excluded.
Note: If the tilting head type with a short focusing unit is required, please contact your local Mitutoyo sales office.

Optional Accessories for Microscopes

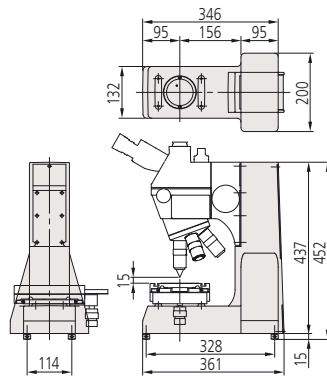
Stand

For mounting the VMU, WIDE VMU, or FS70 microscope unit. Can be combined with an XY stage, stage illumination unit and fiber-optic illuminator to work as a compact microscope for surface observation.



Code No.	378-730
Mass	6.7 kg

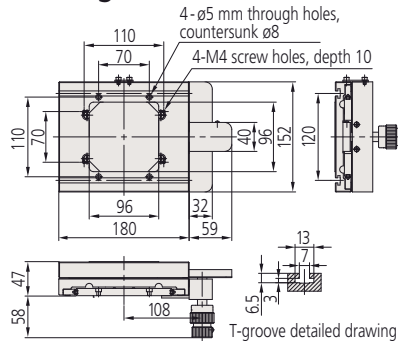
Stand with XY stage and stage illumination unit mounted on FS70Z with optional objectives and eyepieces



Unit: mm

XY stage

Unit: mm

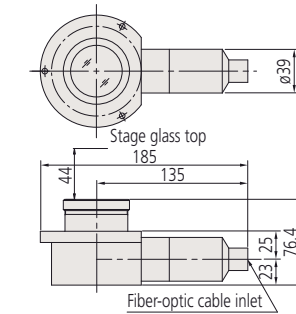


Code No.	378-020
Travel Range	50x50 mm
Handle Feed	34 mm/rev.
Mass	3.3 kg

Note: Each wheel functions as a single-axis drive.

Stage Illumination Unit

Attaches to the stand to provide contour illumination in conjunction with a fiber-optic illuminator.

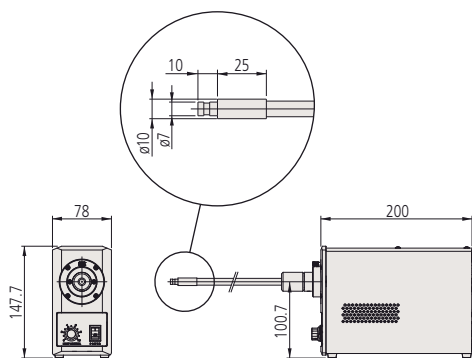


Code No.	378-736
Mass	0.8 kg

Unit: mm

Fiber-Optic Illuminator (LED)

Unit: mm



Code No.	176-386
Light Source	White, 30,000 h service life*1, 6,500K (typ.)*2
Rated Input	AC 100 V - AC 240 V ±10%, 50/60 Hz
Rated Power Consumption	20 W
Light Guide	Fiber-optic cable (1.5 m length, 5 mm dia.)
Brightness	Adjustable by volume

*1: The LED service life may vary depending on the usage environment. This value is not a guarantee of the service life.
*2: Color temperature (given as reference)

Objectives for Bright-Field Observation
(Long Working Distance)

M Plan Apo /
M Plan Apo HR

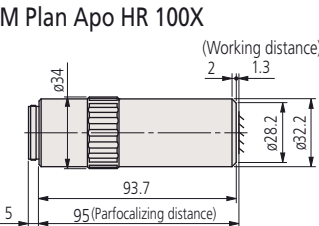
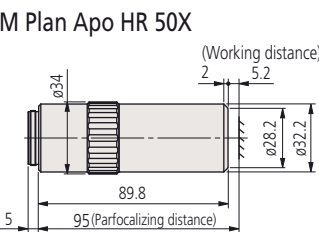
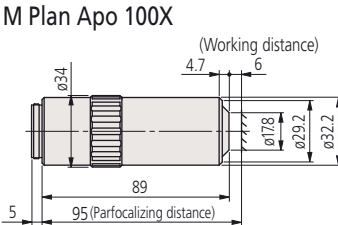
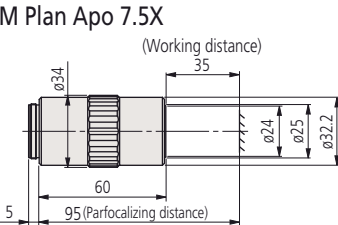
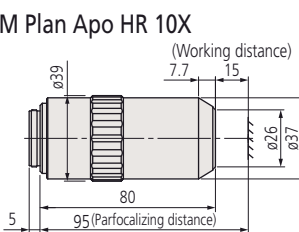
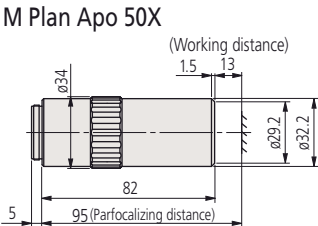
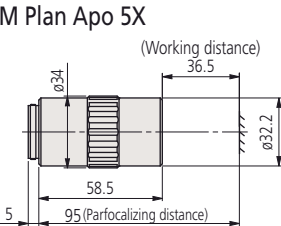
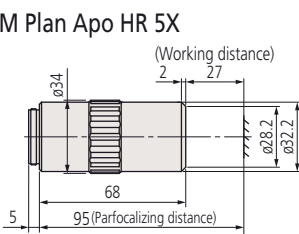
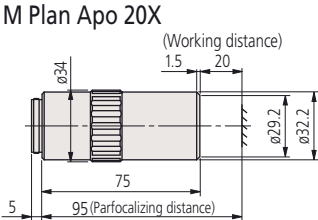
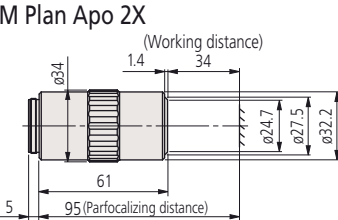
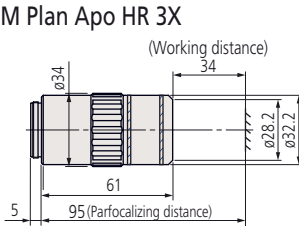
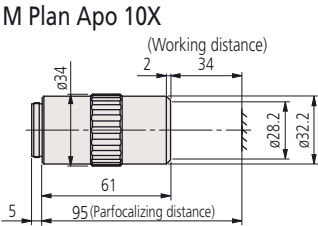
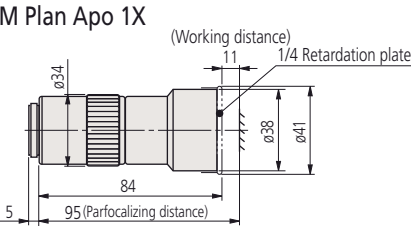
VMU WIDE VMU FS70 MF-U Hyper MF-U



- Features
- > Bright-field observation
 - > Wavelength compensation range 436 nm to 656 nm (Designed to fundamental wavelength 587 nm)
 - > Infinity corrected
 - > Long working distance
 - > Plan-Apochromat
 - > High-resolving power type (M Plan Apo HR)

Dimensions

Unit: mm



Specifications

Model	Code No.	N.A.	W.D. (mm)	f (mm) (λ=550 nm)	R (μm) (λ=550 nm)	±DOF (μm)	Real FOV (mm)		Mass (g)
							Field Number of Visible Wavelength Range ø30	2/3 Inch Camera	
M Plan Apo									
M Plan Apo 1X *1	378-800-12	0.025	11.0	200	11.0	440	30	6.6x8.8	380
M Plan Apo 2X *2	378-801-12	0.055	34.0	100	5.0	91	15	3.3x4.4	240
M Plan Apo 5X	378-802-12	0.14	36.5	40	2.0	14	6	1.32x1.76	270
M Plan Apo 7.5X	378-807-3	0.21	35.0	26.67	1.3	6.2	4	0.88x1.17	280
M Plan Apo 10X	378-803-3	0.28	34.0	20	1.0	3.5	3	0.66x0.88	250
M Plan Apo 20X	378-804-3	0.42	20.0	10	0.7	1.6	1.5	0.33x0.44	330
M Plan Apo 50X	378-805-3	0.55	13.0	4	0.5	0.9	0.6	0.13x0.18	350
M Plan Apo 100X	378-806-3	0.70	6.0	2	0.4	0.6	0.3	0.07x0.09	400
M Plan Apo HR									
M Plan Apo HR 3X *3	Contact Mitutoyo	0.126	34.0	66.7	2.2	17.3	10	2.20x2.93	270
M Plan Apo HR 5X *3	378-787-16	0.21	27.0	40	1.3	6.2	6	1.32x1.76	310
M Plan Apo HR 10X *3	378-788-15	0.42	15.0	20	0.7	1.60	3	0.66x0.88	470
M Plan Apo HR 50X	378-814-4	0.75	5.2	4	0.4	0.49	0.6	0.13x0.18	410
M Plan Apo HR 100X	378-815-4	0.90	1.3	2	0.3	0.34	0.3	0.07x0.09	460

• Every resolution and single objective's depth of focus in the above table is a value determined on the basis of a reference wavelength (λ=0.55 μm).
*1: When observing a workpiece whose optical reflectance is low, an appropriate polarizer should be used with this lens.
*2: When observing a workpiece whose optical reflectance is low, using this lens with a 1/4 wave plate and polarization unit (No.02ALN370) is recommended.
*3: These specifications apply to the objectives in isolation and may not apply when a lens is mounted in the revolver of a microscope, depending on the design of that microscope. In the case where the vertical epi-illumination is provided by the user it is important to balance the various optical parameters so that optimum illumination of the target surface is obtained. Contact your local Mitutoyo Sales Office for information on how this may be achieved.

Objectives for Bright-Field Observation
(Super-Long Working Distance)

M Plan Apo SL

VMU WIDE VMU FS70 MF-U Hyper MF-U

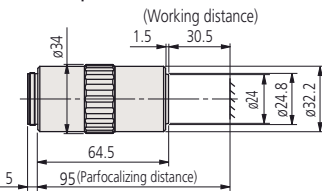
- Features
- > Bright-field observation
 - > Wavelength compensation range 436 nm to 656 nm (Designed to fundamental wavelength 587 nm)
 - > Infinity corrected
 - > Super long working distance
 - > Plan-Apochromat

Dimensions

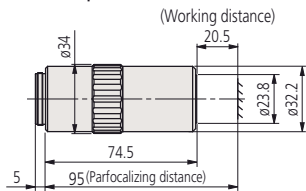


Unit: mm

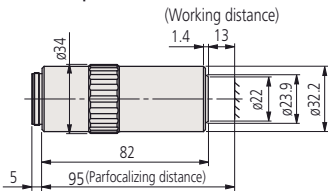
M Plan Apo SL20X



M Plan Apo SL50X



M Plan Apo SL100X



Specifications

Model	Code No.	N.A.	W.D. (mm)	f (mm) (λ=550 nm)	R (μm) (λ=550 nm)	±DOF (μm)	Real FOV (mm)		Mass (g)
							Field Number of Visible Wavelength Range ø30	2/3 Inch Camera	
M Plan Apo SL									
M Plan Apo SL20X	378-810-3	0.28	30.5	10	1.0	3.5	1.5	0.33x0.44	290
M Plan Apo SL50X	378-811-15	0.42	20.5	4	0.7	1.6	0.6	0.13x0.18	340
M Plan Apo SL100X	378-813-3	0.55	13.0	2	0.5	0.9	0.3	0.07x0.09	360

• Every resolution and single objective's depth of focus in the above table is a value determined on the basis of a reference wavelength (λ=0.55 μm).

Objectives for Bright-Field Observation
(With Cover-Glass Thickness Compensation)

G Plan Apo

VMU WIDE VMU FS70 MF-U Hyper MF-U

- Features
- > Bright-field observation
 - > Wavelength compensation range 436 nm to 656 nm (Design to fundamental wavelength 587 nm)
 - > Infinity corrected
 - > Long working distance
 - > Plan-Apochromat
 - > Design enables observation through a 3.5 mm cover glass (material: BK7).

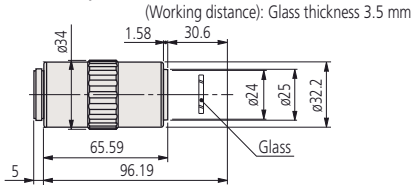
Note: Mitutoyo is ready to design and manufacture a specific sheet of glass according to a specified glass thickness, material or refractive index, please contact your local Mitutoyo sales office.



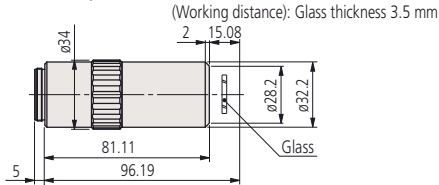
Unit: mm

Dimensions

G Plan Apo 20X



G Plan Apo 50X



Specifications

Model	Code No.	N.A.	W.D. (mm)	f (mm) (λ=550 nm)	R (μm) (λ=550 nm)	±DOF (μm)	Real FOV (mm)		Mass (g)
							Field Number of Visible Wavelength Range ø30	2/3 Inch Camera	
G Plan Apo									
G Plan Apo 20X (t3.5)	378-847	0.28	29.42	10	1.0	3.5	1.5	0.33x0.44	310
G Plan Apo 50X (t3.5)	378-848-3	0.50	13.89	4	0.6	1.1	0.6	0.13x0.18	380

• Every resolution and single objective's depth of focus in the above table is a value determined on the basis of a reference wavelength (λ=0.55 μm).

Objectives for Bright/Dark-Field Observation
(Long Working Distance)

BD Plan Apo

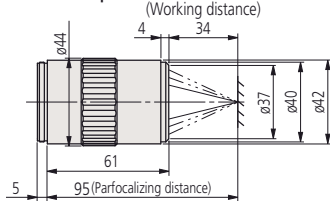
WIDE VMU FS70 MF-U Hyper MF-U

- Features
- > Bright/dark-field observation
 - > Wavelength compensation range 436 nm to 656 nm (Designed to fundamental wavelength 587 nm)
 - > Infinity corrected
 - > Long working distance
 - > Plan-Apochromat

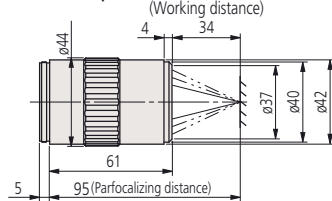


Dimensions

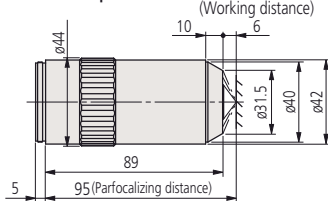
BD Plan Apo 2X



BD Plan Apo 10X

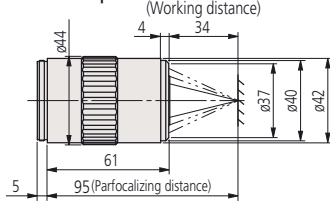


BD Plan Apo 100X

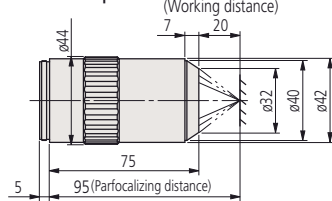


Unit: mm

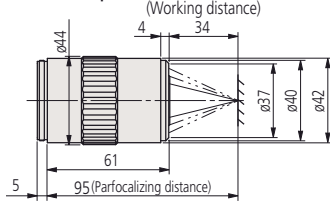
BD Plan Apo 5X



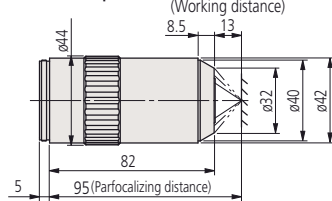
BD Plan Apo 20X



BD Plan Apo 7.5X



BD Plan Apo 50X



Specifications

Model	Code No.	N.A.	W.D. (mm)	f (mm) (λ=550 nm)	R (μm) (λ=550 nm)	±DOF (μm)	Real FOV (mm)		Mass (g)
							Field Number of Visible Wavelength Range ø30	2/3 Inch Camera	
BD Plan Apo									
BD Plan Apo 2X *	378-831-13	0.055	34.0	100	5.0	91	15	3.3x4.4	340
BD Plan Apo 5X	378-832-12	0.14	34.0	40	2.0	14	6	1.32x1.76	370
BD Plan Apo 7.5X	378-830-7	0.21	34.0	26.67	1.3	6.2	4	0.88x1.17	370
BD Plan Apo 10X	378-833-7	0.28	34.0	20	1.0	3.5	3	0.66x0.88	350
BD Plan Apo 20X	378-834-7	0.42	20.0	10	0.7	1.6	1.5	0.33x0.44	420
BD Plan Apo 50X	378-835-7	0.55	13.0	4	0.5	0.9	0.6	0.13x0.18	450
BD Plan Apo 100X	378-836-7	0.70	6.0	2	0.4	0.6	0.3	0.07x0.09	510

• Every resolution and single objective's depth of focus in the above table is a value determined on the basis of a reference wavelength (λ=0.55 μm).

* It is recommended to be used together with the 1/4 wavelength plate B (02ALN380) and appropriate polarizer for the microscope used (Working distance will be shortened 4 mm).

Near-Infrared Radiation Range Objectives for Bright-Field Observation

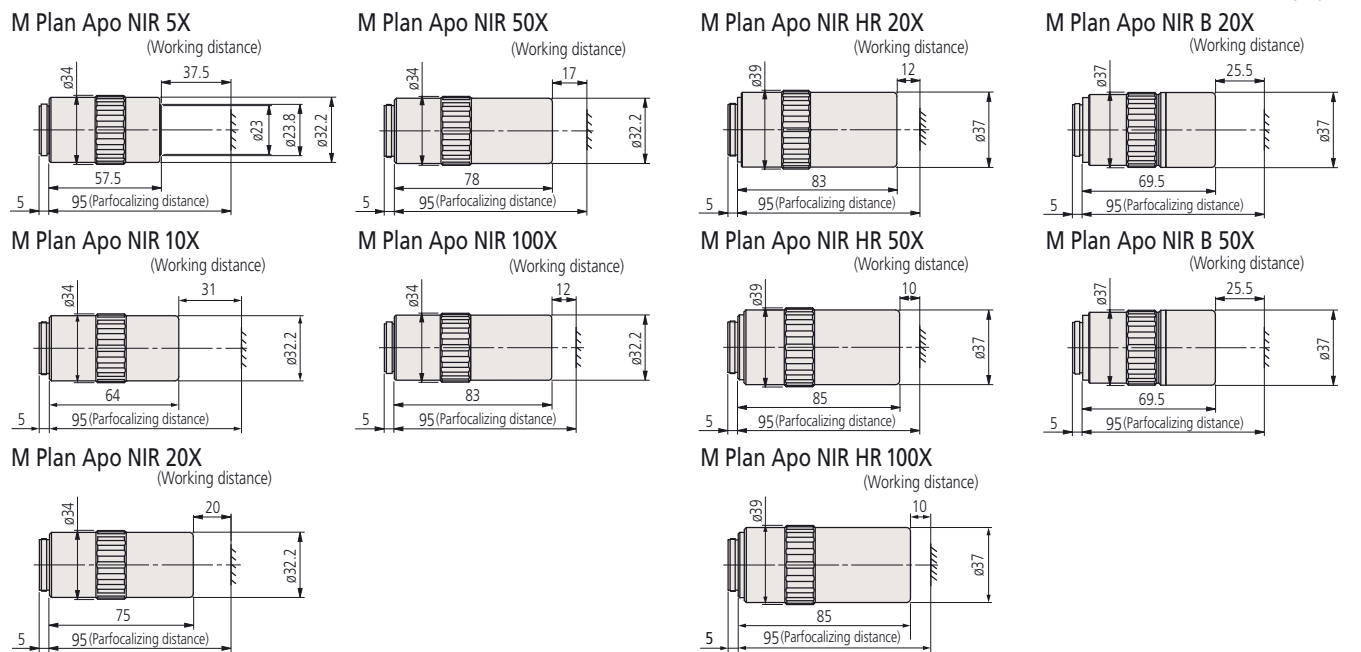
M Plan Apo NIR /
M Plan Apo NIR HR /
M Plan Apo NIR B

VMU WIDE VMU FS70

- Features
- > Bright-field observation/Near-infrared observation/Laser machining
 - > Wavelength compensation range 480 nm to 1800 nm (M Plan Apo NIR B: 420 nm to 1064 nm)
 - > Infinity corrected
 - > Long working distance
 - > Plan-Apochromat
 - > High-resolving power typ (M Plan Apo NIR HR)
 - > Ultra-long working distance and High spectral transmission factor (M Plan Apo NIR B)



Dimensions



Specifications

Model	Code No.	N.A.	W.D. (mm)	f (mm) (λ= 550 nm)	R (μm) (λ= 550 nm)	±DOF (μm)	Real FOV (mm)		Mass (g)
							Field Number of Visible/ Near-Infrared Wavelength Range ø30	2/3 Inch Camera	
M Plan Apo NIR									
M Plan Apo NIR 5X	378-822-5	0.14	37.5	40	2.0	14.0	6	1.32x1.76	260
M Plan Apo NIR 10X	378-823-15	0.26	31.0	20	1.1	4.1	3	0.66x0.88	270
M Plan Apo NIR 20X	378-824-16	0.40	20.0	10	0.7	1.7	1.5	0.33x0.44	320
M Plan Apo NIR 50X	378-825-17	0.42	17.0	4	0.7	1.6	0.6	0.13x0.18	360
M Plan Apo NIR 100X	378-826-15	0.50	12.0	2	0.6	1.1	0.3	0.07x0.09	380
M Plan Apo NIR HR									
M Plan Apo NIR HR 20X	378-854	0.60	12.0	10	0.46	0.8	1.5	0.33x0.44	470
M Plan Apo NIR HR 50X	378-863-5	0.65	10.0	4	0.4	0.7	0.6	0.13x0.18	530
M Plan Apo NIR HR 100X	378-864-15	0.70	10.0	2	0.4	0.6	0.3	0.07x0.09	520
M Plan Apo NIR B									
M Plan Apo NIR B 20X	378-867-5	0.40	25.5	10	0.7	1.7	1.5	0.33x0.44	370
M Plan Apo NIR B 50X	378-868-5	0.42	25.5	4	0.7	1.6	0.6	0.13x0.18	390

• Every resolution and single objective's depth of focus in the above table is a value determined on the basis of a reference wavelength ($\lambda=0.55 \mu$ m).
Note: If the wavelength used is 1100 nm or longer, the focal point may deviate slightly from that in visible radiation.

Near-Infrared Radiation Range Objectives for Bright-Field Observation (With Cover-Glass Thickness Compensation)

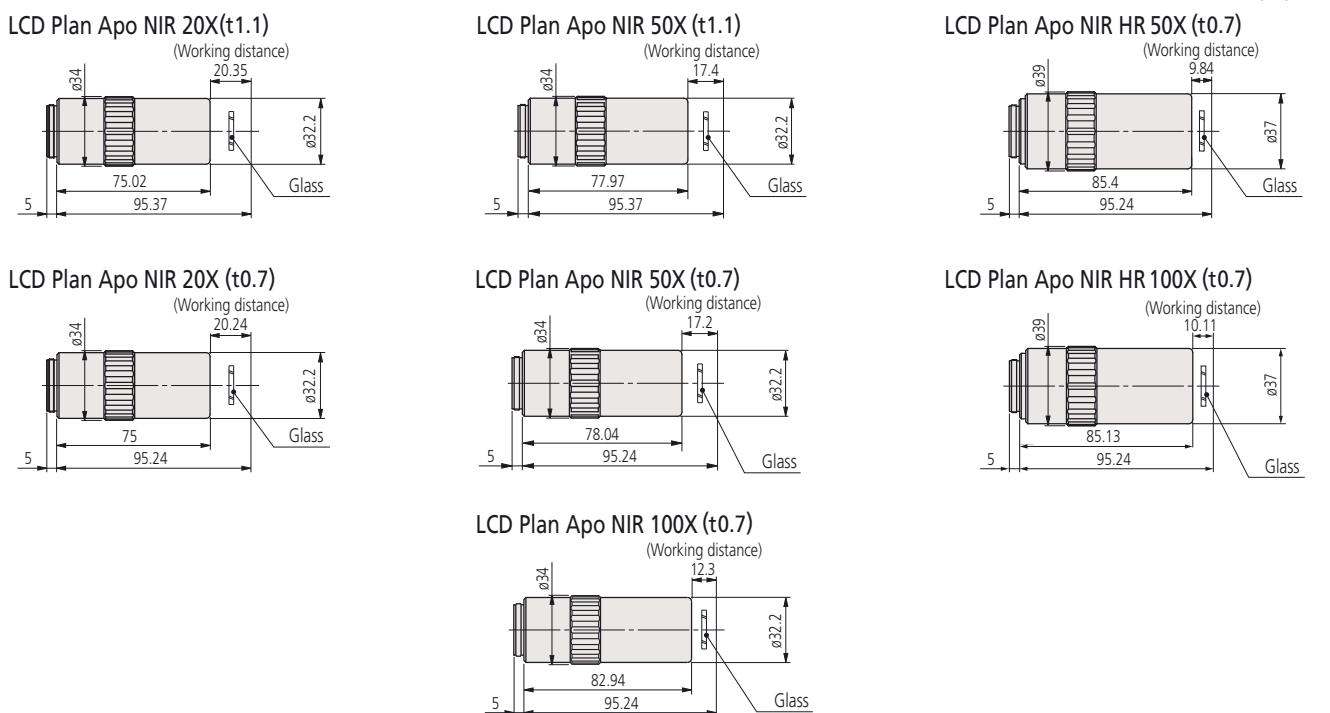
LCD Plan Apo NIR /
LCD Plan Apo NIR HR

VMU WIDE VMU FS70

- Features
- > Bright-field observation/Near-infrared observation/Laser machining
 - > Wavelength compensation range 480 nm to 1800 nm
 - > Infinity corrected
 - > Long working distance
 - > Plan-Apochromat
 - > Design enables observation through a 3.5 mm or 1.1 mm cover glass (material: BK7).
- Note: Mitutoyo is ready to design and manufacture a specific sheet of glass according to a specified glass thickness, material or refractive index, please contact your local Mitutoyo sales office.
- > High-resolving power typ (LCD Plan Apo NIR HR)



Dimensions



Specifications

Model	Code No.	N.A.	W.D. (mm)	f (mm) ($\lambda=550$ nm)	R (μ m) ($\lambda=550$ nm)	$\pm$ DOF (μ m)	Real FOV (mm)		Mass (g)
							Field Number of Visible/ Near-Infrared Wavelength Range $\phi 30$	2/3 Inch Camera	
LCD Plan Apo NIR									
LCD Plan Apo NIR 20X (t1.1)	378-827-16	0.40	19.98	10	0.7	1.7	1.5	0.33x0.44	320
LCD Plan Apo NIR 20X (t0.7)	378-821-16	0.40	20.00	10	0.7	1.7	1.5	0.33x0.44	320
LCD Plan Apo NIR 50X (t1.1)	378-828-17	0.42	17.03	4	0.7	1.6	0.6	0.13x0.18	360
LCD Plan Apo NIR 50X (t0.7)	378-829-17	0.42	16.96	4	0.7	1.6	0.6	0.13x0.18	360
LCD Plan Apo NIR 100X (t0.7)	378-754-15	0.50	12.06	2	0.6	1.1	0.3	0.07x0.09	380
LCD Plan Apo NIR HR									
LCD Plan Apo NIR HR 50X (t0.7)	378-869-5	0.65	9.6	4	0.4	0.7	0.6	0.13x0.18	520
LCD Plan Apo NIR HR 100X (t0.7)	378-870-15	0.70	9.87	2	0.4	0.7	0.3	0.07x0.09	520

• Every resolution and single objective's depth of focus in the above table is a value determined on the basis of a reference wavelength ($\lambda=0.55 \mu$ m).

Near-Ultraviolet Radiation Range
Objectives for Bright-Field Observation

M Plan Apo NUV /
M Plan Apo NUV HR

VMU FS70

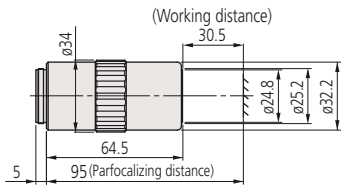
- Features
- > Bright-field observation/Near-ultraviolet observation/Laser machining
 - > Wavelength compensation range 355 nm to 620 nm
 - > Infinity corrected
 - > Long working distance
 - > Plan-Apochromat
 - > High-resolving power typ (M Plan Apo NUV HR)



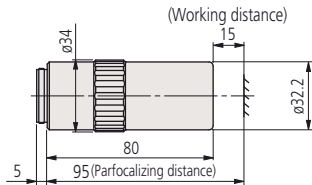
Dimensions

Unit: mm

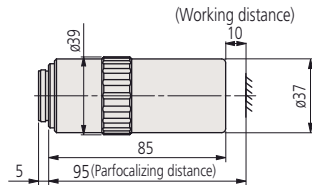
M Plan Apo NUV 10X



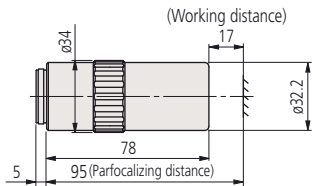
M Plan Apo NUV 50X



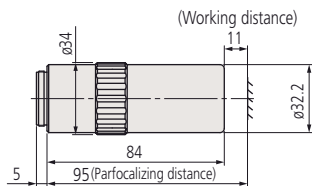
M Plan Apo NUV HR 50X



M Plan Apo NUV 20X



M Plan Apo NUV 100X



Specifications

Model	Code No.	N.A.	W.D. (mm)	f (mm) (λ=550 nm)	R (μm) (λ=550 nm)	±DOF (μm)	Real FOV (mm)			Mass (g)
							Field Number of Visible Wavelength Range ø30	Field Number of Near-Ultraviolet Wavelength Range ø16	2/3 Inch Camera	
M Plan Apo NUV										
M Plan Apo NUV 10X	378-809-5	0.28	30.5	20	1	3.5	3	1.6	0.66×0.88	270
M Plan Apo NUV 20X	378-817-8	0.42	17.0	10	0.7	1.6	1.5	0.8	0.33×0.44	360
M Plan Apo NUV 50X	378-818-8	0.44	15.0	4	0.6	1.4	0.6	0.32	0.13×0.18	410
M Plan Apo NUV 100X	378-819-15	0.50	11.0	2	0.6	1.1	0.3	0.16	0.07×0.09	430
M Plan Apo NUV HR										
M Plan Apo NUV HR 50X	378-888-6	0.65	10.0	4	0.42	0.65	0.6	0.32	0.13×0.18	570

• Every resolution and single objective's depth of focus in the above table is a value determined on the basis of a reference wavelength (λ=0.55 μm).

Near-Ultraviolet Radiation Range Objectives for Bright-Field
Observation (With Cover-Glass Thickness Compensation)

LCD Plan Apo NUV /
LCD Plan Apo NUV HR

VMU FS70

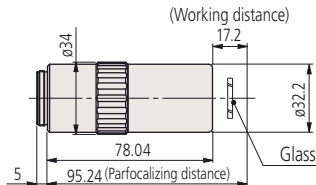
- Features
- > Bright-field observation/Near-ultraviolet observation/Laser machining
 - > Wavelength compensation range 355 nm to 620 nm
 - > Infinity corrected
 - > Long working distance
 - > Plan-Apochromat
 - > Design enables observation through a 3.5 mm cover glass (material: BK7).
 - Note: Mitutoyo is ready to design and manufacture a specific sheet of glass according to a specified glass thickness, material or refractive index, please contact your local Mitutoyo sales office.
 - > High-resolving power typ (LCD Plan Apo NUV HR)



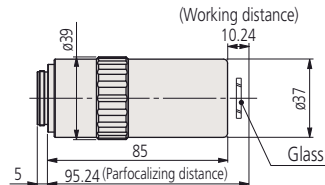
Dimensions

Unit: mm

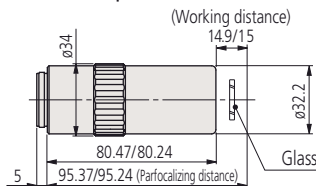
LCD Plan Apo NUV 20X (t0.7)



LCD Plan Apo NUV HR 50X (t0.7)



LCD Plan Apo NUV 50X (t0.7)



Specifications

Model	Code No.	N.A.	W.D. (mm)	f (mm) (λ=550 nm)	R (μm) (λ=550 nm)	±DOF (μm)	Real FOV (mm)			Mass (g)
							Field Number of Visible Wavelength Range ø30	Field Number of Near-Ultraviolet Wavelength Range ø16	2/3 Inch Camera	
LCD Plan Apo NUV										
LCD Plan Apo NUV 20X (t0.7)	378-890-8	0.42	16.96	10	0.7	1.6	1.5	0.8	0.33×0.44	360
LCD Plan Apo NUV 50X (t0.7)	378-820-8	0.44	14.76	4	0.6	1.4	0.6	0.32	0.13×0.18	410
LCD Plan Apo NUV HR										
LCD Plan Apo NUV HR 50X (t0.7)	378-891-6	0.65	9.76	4	0.4	0.7	0.6	0.32	0.13×0.18	570

• Every resolution and single objective's depth of focus in the above table is a value determined on the basis of a reference wavelength (λ=0.55 μm).

Ultraviolet Radiation Range Objectives for Bright-Field Observation

M Plan UV

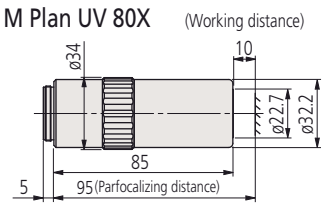
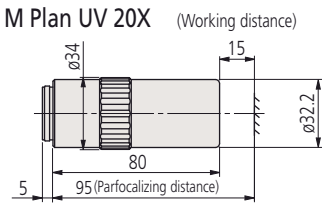
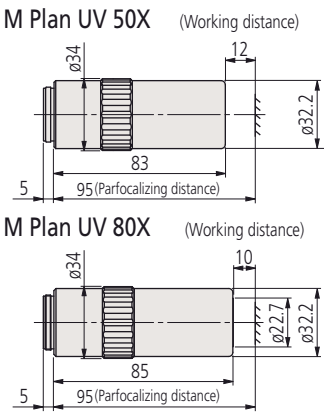
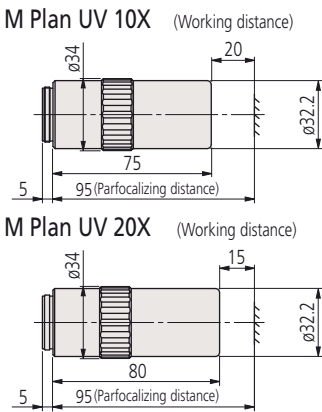
VMU FS70

- Features
- > Bright-field observation/Ultraviolet observation/Laser machining
 - > Wavelength compensation 266 nm and 550 nm
 - > Infinity corrected
 - > Long working distance
 - > Plan



Dimensions

Unit: mm



Specifications

Model	Code No.	N.A.	W.D. (mm)	f (mm)		R (μm) (λ=550 nm)	±DOF (μm)	Real FOV (mm)			Mass (g)
				f ₂₆₆	f ₅₅₀			Field Number of Visible Wavelength Range ø30	Field Number of Near-Ultraviolet Wavelength Range ø16	2/3 Inch Camera	
M Plan UV											
M Plan UV 10X	378-844-15	0.25	20.0	20	20.3	1.1	4.4	3	1.6	0.66×0.88	350
M Plan UV 20X	378-837-8	0.37	15.0	10	10.4	0.7	2.0	1.5	0.8	0.33×0.44	390
M Plan UV 50X	378-838-8	0.41	12.0	4	4.2	0.7	1.6	0.6	0.32	0.13×0.18	400
M Plan UV 80X	378-839-5	0.55	10.0	2.5	2.9	0.5	0.9	0.375	0.2	0.08×0.11	430

- When projecting a mask image on a specimen by using a YAG laser system mounted on a Mitutoyo microscope unit, the mask image will be scaled by the factor f/200 times (f=200 mm, Mitutoyo tube lens). Since the focal length (f) in ultraviolet radiation (λ =266 nm) is slightly smaller than that in visible radiation (λ =550 nm) as above, the working area in ultraviolet radiation also becomes slightly smaller than the mask image in visible radiation.
- Every resolution and single objective's depth of focus in the above table is a value determined on the basis of a reference wavelength (λ =0.55 μm).

Ultraviolet Radiation Range Objectives for Bright-Field Observation (With Cover-Glass Thickness Compensation)

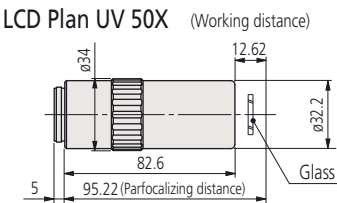
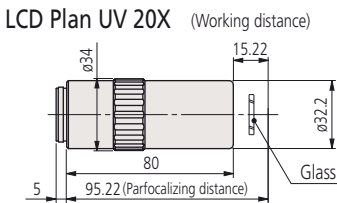
LCD Plan UV

VMU FS70

- Features
- > Bright-field observation/Ultraviolet observation/Laser machining
 - > Wavelength compensation 266 nm and 550 nm
 - > Infinity corrected
 - > Long working distance
 - > Plan
 - > Design enables observation through a 3.5 mm cover glass (material: sio2).
- Note: Mitutoyo is ready to design and manufacture a specific sheet of glass according to a specified glass thickness, material or refractive index, please contact your local Mitutoyo sales office.

Dimensions

Unit: mm



Specifications

Model	Code No.	N.A.	W.D. (mm)	f (mm)		R (μm) (λ=550 nm)	±DOF (μm)	Real FOV (mm)			Mass (g)
				f ₂₆₆	f ₅₅₀			Field Number of Visible Wavelength Range ø30	Field Number of Near-Ultraviolet Wavelength Range ø16	2/3 Inch Camera	
LCD Plan UV											
LCD Plan UV 20X (t0.7)	378-892-8	0.37	14.98	10	10.4	0.7	2.0	0.8	0.8	0.33×0.44	400
LCD Plan UV 50X (t0.7)	378-893-8	0.41	12.38	4	4.2	0.7	1.6	0.32	0.32	0.13×0.18	400

- When projecting a mask image on a specimen by using a YAG laser system mounted on a Mitutoyo microscope unit, the mask image will be scaled by the factor f/200 times (f=200 mm, Mitutoyo tube lens). Since the focal length (f) in ultraviolet radiation (λ=266 nm) is slightly smaller than that in visible radiation (λ=550 nm) as above, the working area in ultraviolet radiation also becomes slightly smaller than the mask image in visible radiation.
- Every resolution and single objective's depth of focus in the above table is a value determined on the basis of a reference wavelength (λ =0.55 μm).

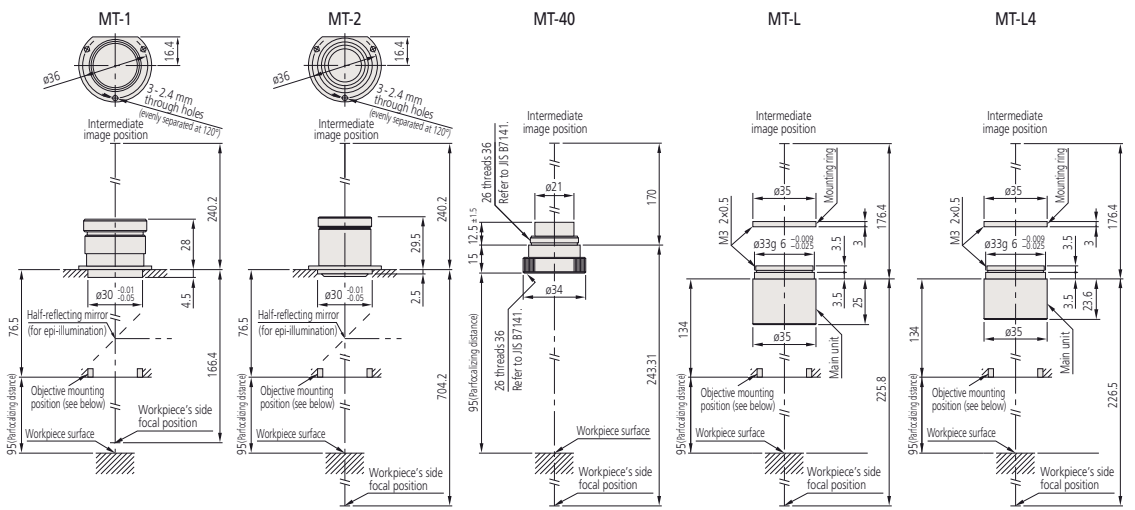
Tube Lens MT

Aberration Correction Range

MT-1, 2, 40: Visible wavelength range (435.8 – 656.3 nm)
MT-L: Near-ultraviolet (355 nm) to near-infrared (1800 nm)
MT-L4: Ultraviolet (266 nm) to visible (620 nm).

Unit: mm

Dimensions



Specifications

Model	Code No.	Focal length (mm)	Magnification (Tube Lens)	Image Field (mm)	Effective Lens Dia. (mm)	Dimensions (mm)	Mass (g)
MT-1	970208	200	1X	30	24.0	40x32.5	43
MT-2	970209	400	2X	30	18.0	40x32.0	42
MT-40	378-010	200	1X	24	11.2	34x27.5	45
MT-L	378-008	200	1X	24	22.0	35x32.0	30
MT-L4	378-009	200	1X	24	23.0	35x30.6	30

Note: A distance of 76.5mm in 970208 and 970209 drawings is for an image field of 30 (without vignetting). For an image field of 24 or 11 (the latter is the image field of a 2/3-inch camera), use the formula (1) and (2) below to calculate the distance.

Reference: Placement of Objective and Tube Lens

VMU and WIDE VMU and FS70 employs an infinity-corrected optical system in which the image is created by an objective lens and an imaging (tube) lens. Mitutoyo's long working-distance objective lenses are designed to cover a field of view of up to 30 mm (when the tube lens **970208** or **970209** is placed) and up to 24 mm (when the tube lens **378-008**, **378-009** or **378-010** is placed) at the specified distance from the objective. However, use the following formula to calculate the approximate distance, when a distance other than that as specified is required in order to insert your own optical system or other optical elements:

$$\ell = (\phi_2 - \phi_1) \cdot f_2 / \phi \text{ [mm]} \dots\dots\dots (1)$$
$$\phi_1 = 2 \cdot f \cdot \text{N.A. [mm]} \dots\dots\dots (2)$$

$$\phi_1: \text{Objective exit pupil diameter (mm)}$$
$$\phi_2: \text{Effective diameter of tube lens (mm)}$$
$$f_2: \text{Focal length of tube lens (mm)}$$
$$\phi: \text{Image field diameter (mm)}$$

Example: What is the distance (ℓ), when using **M Plan Apo 10X*** and tube lens** (**970208**) to cover an image field of 24?

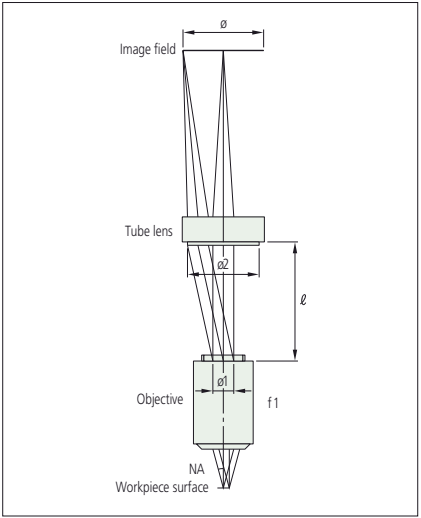
*f=20 mm, N.A.=0.28 (Refer to page 27.) ** ϕ_2 =24 mm, f_2 =200 mm (Refer to the above chart.)

From formula (2): $\phi_1=2 \times 20 \times 0.28$
 $=11.2 \text{ (mm)}$

From formula (1): $\ell = (24 - 11.2) \times 200 / 24$
 $=106.6 \text{ (mm)}$

Therefore a distance (ℓ) up to 106 mm can cover an image field of 24 without shading.

In other words a distance (ℓ) smaller than the specification does not affect optical performance.
Contact Mitutoyo for detailed information.



Objectives for Measuring Microscopes ML

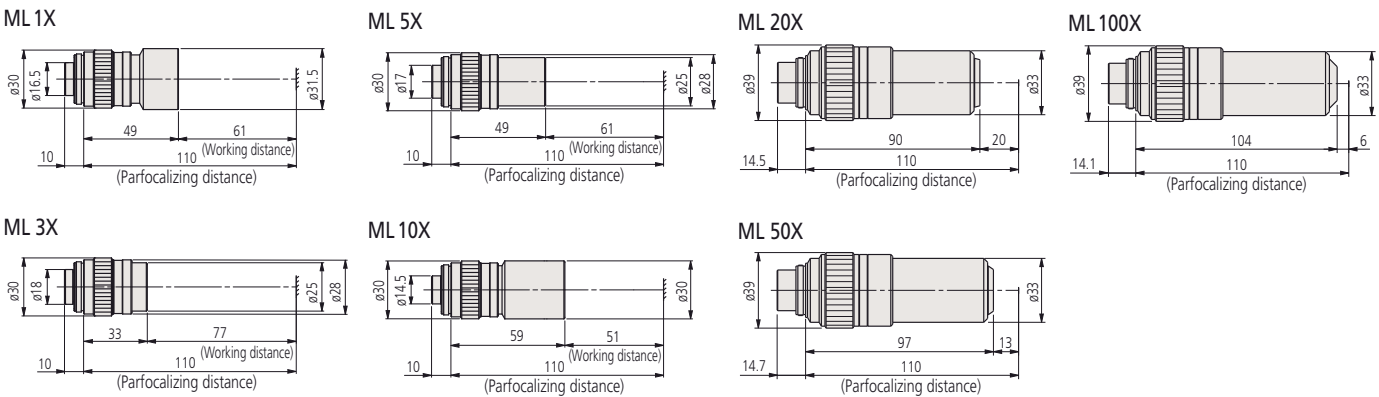
MF Hyper MF

Features

- >Bright field measurement
- >Wavelength range: 436 to 656 nm (Designed to fundamental wavelength 587 nm)
- >Finite-correction (image-object distance: 280 mm, parfocalizing distance: 110 mm)



Dimensions



Note: The parfocalizing distance is a nominal value.

Specifications

Model	Code No.	N.A.	W.D. (mm)	R (μm) (λ = 550 nm)	±DOF (μm)	Real FOV (mm)		Mass (g)
						24 Eyepiece	1/2 Inch Camera	
ML 1X	375-036-2	0.03	61.0	9.2	306	24	4.8x6.4	80
ML 3X	375-037-1	0.09	77.0	3.06	34	8	1.6x2.1	55
ML 5X	375-034-1	0.13	61.0	2.12	16.3	4.8	0.96x1.28	75
ML 10X	375-039	0.21	51.0	1.31	6.2	2.4	0.48x0.64	95
ML 20X	375-051	0.42	20.0	0.65	1.6	1.2	0.24x0.32	370
ML 50X	375-052	0.55	13.0	0.5	0.9	0.48	0.10x0.13	390
ML 100X	375-053	0.70	6.0	0.4	0.6	0.24	0.05x0.06	440

• Every resolution and single objective's depth of focus in the above table is a value determined on the basis of a reference wavelength (λ = 0.55 μm).

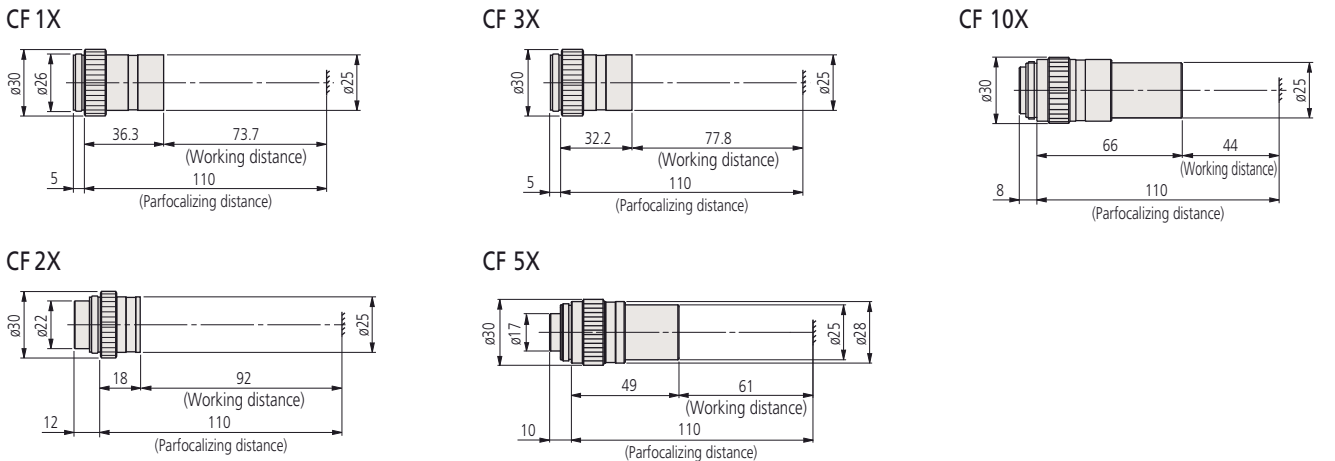
Objectives for Centering Microscopes

CF

CF

- Features**
- > Finite-correction
(image-object distance: 280 mm, parfocalizing distance: 110 mm)
 - > Bright-field observation
 - > Long working distance

Dimensions



Note: The parfocalizing distance is a nominal value.

Specifications

Model	Code No.	N.A.	W.D. (mm)	R (μm) ($\lambda=550\text{ nm}$)	$\pm\text{DOF}$ (μm)	Real FOV (mm)		Mass (g)
						$\phi 24$ Eyepiece	1/2 Inch Camera	
CF 1X	375-031	0.03	73.7	9.2	306	24	4.8x6.4	45
CF 2X	375-032	0.06	92.0	4.6	76	12	2.4x3.2	35
CF 3X	375-033	0.07	77.8	3.9	56	8	1.6x2.1	35
CF 5X	375-034-1	0.13	61.0	2.12	16.3	4.8	0.96x1.28	75
CF 10X	375-035	0.18	44.0	1.5	8	2.4	0.48x0.64	100

• Every resolution and single objective's depth of focus in the above table is a value determined on the basis of a reference wavelength ($\lambda=0.55\text{ }\mu\text{m}$).

Wide Field of View Eyepieces and Reticles

WF

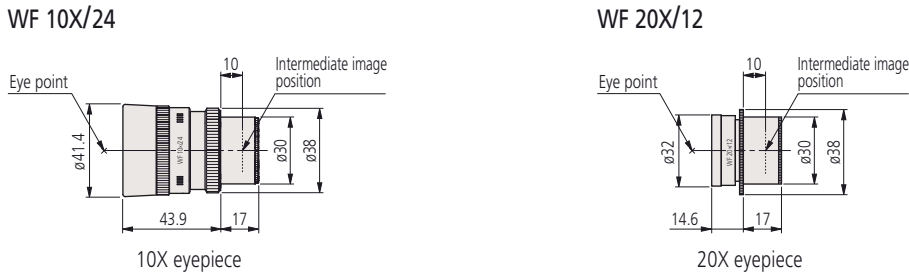
MF MF-U Hyper MF Hyper MF-U FS70

- Features**
- > Eyepiece for wide field of view
 - > Adopt an outside focus type of optical system
 - > Various reticles can be attached according to usage purposes



Dimensions

Unit: mm



Specifications

Model	Code No. (2pcs.)	Magnification	Field Number	Visibility Adjustment	Eye Point	Reticle	Mass (g)
Wide field of view eyepiece WF10X/24	378-866	10X	24	-10D to +5D	High eye point	Available	150
Wide field of view eyepiece WF20X/12	378-858	20X	12	-8D to +5D	Normal	Available	55

Note: The above lenses are provided as a set of 2.

Reticles

- Features**
- > Simple dimensional measurement is possible by inserting into the eyepiece (intermediate image position): No.378-866, 378-857, and 378-858
 - > Reticle line width 10 μm ...No.516576 only 7 μm
 - > Outer diameter $\phi 25\text{ mm}$, thickness 1 mm

Dimensions

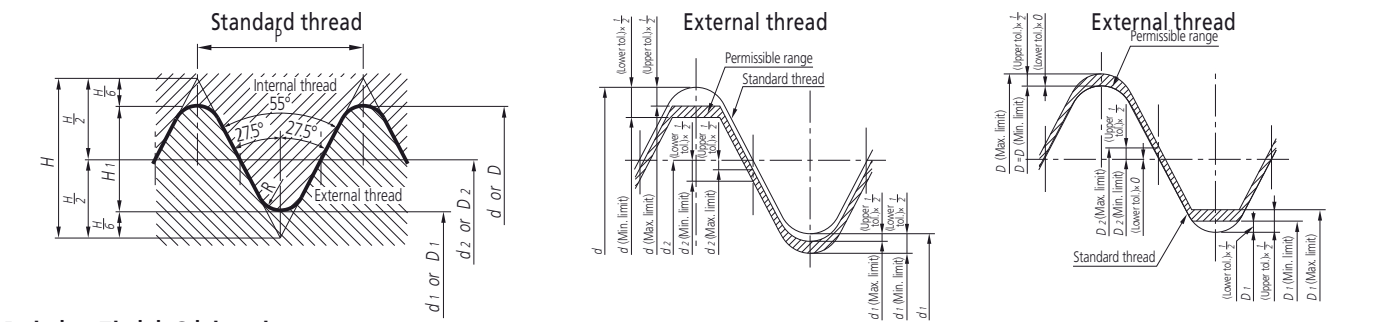


Specifications

Code No.	516848	516576	516578	516577	516849	516850
Remarks	Solid crosshairs	90° and 60° broken crosshairs	Concentric circles ($\phi 1.2\text{ - }18\text{ mm}$) with solid crosshairs	Solid crosshairs with scale graduated 0.1 mm/20 mm	10 mm scale with 0.1 mm graduations	5 mm scale with 0.05 mm graduations

Reference: Specifications of Objective Threads

1. Scope These specifications are applied to the threads of Mitutoyo microscope objectives.
2. The thread forms and dimensions are specified as follows conforming to JIS B-7141-1994.



Bright-Field Objectives Measuring Microscope/Centering Microscope Objectives

Nominal Dimensions Unit: mm

Nominal Thread Diameter	Number of Threads (per 25.4 mm) n	Pitch P	Thread Peak & Valley Curvature Radius R	External Thread		
				OD (d)	Pitch Diameter (d ₂)	Root Diameter (d ₁)
				Root Diameter (D)	Pitch Diameter (D ₂)	ID (D ₁)
26	36	0.706	0.097	26.000	25.548	25.096

Permissible Limits of Size and Dimensional Tolerance Unit: mm

Applicable Dimensions		External Thread			Internal Thread		
		OD (d)	Pitch Diameter (d ₂)	Root Diameter (d ₁)	Root Diameter (D)	Pitch Diameter (D ₂)	ID (D ₁)
Permissible limits	Max. limit	25.896	25.502	25.050	26.076	25.624	25.230
	Min. limit	25.820	25.426	24.974	26.000	25.548	25.154
Dimensional tolerance	Upper tolerance	-0.104	-0.046	-0.046	+0.076	+0.076	+0.134
	Lower tolerance	-0.180	-0.122	-0.122	0	0	+0.058

Bright/Dark-Field Objectives

Nominal Dimensions Unit: mm

Nominal Thread Diameter	Number of Threads (per 25.4 mm) n	Pitch P	Thread Peak & Valley Curvature Radius R	External Thread		
				OD (d)	Pitch Diameter (d ₂)	Root Diameter (d ₁)
				Root Diameter (D)	Pitch Diameter (D ₂)	ID (D ₁)
40	36	0.706	0.097	40.000	39.548	39.096

Permissible Limits of Size and Dimensional Tolerance Unit: mm

Applicable Dimensions		External Thread			Internal Thread		
		OD (d)	Pitch Diameter (d ₂)	Root Diameter (d ₁)	Root Diameter (D)	Pitch Diameter (D ₂)	ID (D ₁)
Permissible limits	Max. limit	39.896	39.502	39.050	40.076	39.624	39.230
	Min. limit	39.820	39.426	38.974	40.000	39.548	39.154
Dimensional tolerance	Upper tolerance	-0.104	-0.046	-0.046	+0.076	+0.076	+0.134
	Lower tolerance	-0.180	-0.122	-0.122	0	0	+0.058

Reference: Transmission of Mitutoyo Objectives

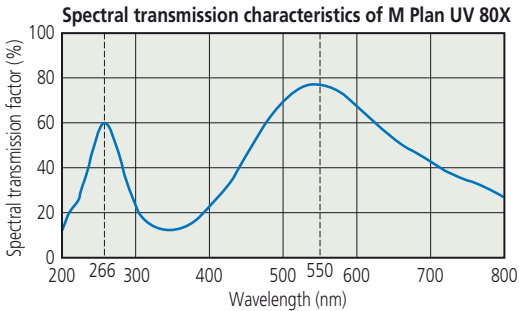
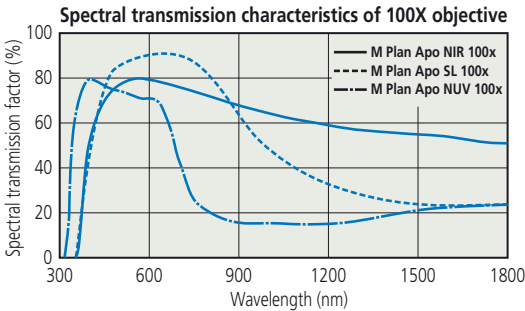
Mitutoyo's long working-distance objectives are grouped by working wavelength range: ultraviolet, near-ultraviolet, visible, and near-infrared. The M Plan UV series (for ultraviolet), M Plan Apo NUV series (for near-ultraviolet), and M Plan Apo NIR series (for near-infrared) are designed especially for YAG laser working applications in cutting thin films. Each series is designed for optimal spectral transmission factor within its respective wavelength range.

M (BD) Plan Apo series: Wavelength range 436 nm to 656 nm

M Plan Apo NIR series: Wavelength range 480 nm to 1800 nm

M Plan Apo NUV series: Wavelength range 355 nm to 620 nm

M Plan UV series: Optimized for wavelengths of 266 nm and 550 nm



N.A.: Numerical aperture W.D.: Working distance f: Focal length R: Resolving power DOF: Depth of field FOV: Real field of view

Commentary: Laser Operating Method and Precautions

Each VMU and FS70 series of Mitutoyo microscope units uses a built-in laser [mainly, Nd-YAG laser fundamental wave (1064 nm), second harmonic (532 nm), third harmonic (355 nm) and fourth harmonic (266 nm)] to allow laser machining. In laser machining with a laser-equipped microscope unit and a microscope objective, high-power laser irradiation is not allowed for the purpose of microfabrication. IMPORTANT: Review laser safety precautions prior to use.

Laser Input Conditions of Laser-Equipped Microscope Unit

Determine the upper limit value of laser input under the following conditions. Laser radiation incident on the optical system shall be axial and non-polarized.

VMU Series

Applicable Model	VMU-LB			VMU-L4B			
Wavelength used (nm)	1064	532	355	1064	532	355	266
Pulse laser							
Upper input limit (J/cm ²)	0.099	0.075	0.025	0.11	0.080	0.035	0.015
Pulse width (10 ns)							
Upper limit to CW laser input (kW/cm ²)	0.22	0.18	0.07	0.2	0.19	0.05	0.05

FS70 Series

Applicable Model	FS70L			FS70L4	
Wavelength used (nm)	1064	532	355	532	266
Pulse laser					
Upper input limit (J/cm ²)	0.090	0.075	0.018	0.075	0.015
Pulse width (10 ns)					
Upper limit to CW laser input (kW/cm ²)	0.23	0.18	0.06	0.2	0.05

Upper Limit to Objective Laser Input

Determine the upper limit value of laser input under the following conditions if the laser radiation directly enters the objective. Laser radiation incident on the optical system shall be axial.

VMU Series

Applicable Objective	NIR series	NIR series NUV series UV series	NUV series	UV series
Wavelength used (nm)	1064	532	355	266
Pulse laser				
Upper input limit (J/cm ²)	0.2	0.1	0.05	0.04
Pulse width (10 ns)				
Upper limit to CW laser input (kW/cm ²)	0.5	0.25	0.16	0.12

Note: If the pulse width of the laser is shortened, reduce the irradiation energy density by the square root of the ratio of the new pulse width to the initial pulse width.
Example: If the pulse width decreases to 1/4 of the initial width, reduce the energy density to approximately 1/2.
Therefore when using a laser with a wavelength of 1064 nm and a pulse width of 2.5 ns, the upper limiting value of input will be 0.1 J/cm².

Glossary

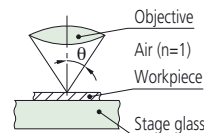
1. N.A. (Numerical Aperture)

N.A. determines resolving power, depth of field, and luminosity of the image. The larger the N.A. the higher is the resolving power and smaller is the depth of field.

$$N.A. = n \cdot \sin \theta$$

n is the index of refraction of the medium in which the lens is working. n=1.0 for air.

θ is the half-angle of the maximum cone of light that can enter or exit the lens.



2. R (Resolving Power)

Minimum distance between points or lines that are just distinguishable as separate entities.

Resolving power is determined by N.A. and wavelength λ.

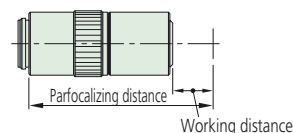
$$R (\mu m) = \frac{\lambda}{2 \cdot N.A.}$$

3. W.D. (Working Distance)

Distance between the surface of the specimen and the front face of the objective when in focus.

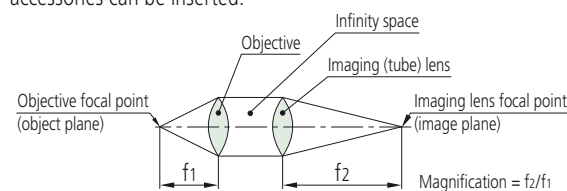
4. Parfocalizing Distance

Distance between the surface of the specimen and the objective's seating surface when in focus.



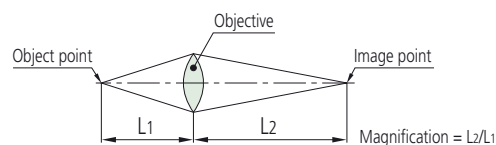
5. Infinity-corrected optical system

An optical system in which the image is formed by an objective and a tube lens with an 'Infinity Space' between them, into which optical accessories can be inserted.



6. Finite-corrected optical system

An optical system in which the image is formed only by an objective lens.



7. F (Focal Length)

Distance between a principal point and a focal point. f¹ is the focal length of an objective, f² is the focal length of a tube lens. Magnification is determined by the ratio of the focal length of the tube lens to that of the objective. (For an infinity-corrected optical system.)

$$\text{Magnification of objective} = \frac{\text{Focal length of tube lens}}{\text{Focal length of objective}}$$

$$\text{(E.g.) } 1X = \frac{200 \text{ (mm)}}{200 \text{ (mm)}} \quad \text{(E.g.) } 10X = \frac{200 \text{ (mm)}}{20 \text{ (mm)}}$$

8. Field Number and FOV (Real Field of View)

The field number of an eyepiece is determined by the field stop diameter of the eyepiece and it is expressed in mm.

FOV is the area of specimen observable and is determined by the field number of the eyepiece and magnification of the objective.

$$\text{FOV (mm)} = \frac{\text{Field number of eyepiece}}{\text{Magnification of objective}}$$

(E.g. Using an eyepiece of field number 24)

$$\text{FOV for 1X objective} = \frac{24}{1} = \phi 24 \text{ (mm)}$$

$$\text{FOV for 10X objective} = \frac{24}{10} = \phi 2.4 \text{ (mm)}$$

Area of specimen observable on TV monitor

$$\text{Area of specimen observable on TV monitor} = \frac{\text{Area of camera image element (VxH)}}{\text{Magnification of objective}}$$

Indication magnification on TV monitor

$$\text{Indication magnification on TV monitor} = \text{Magnification of objective} \times \frac{\text{Diagonal line length of monitor indication}}{\text{Diagonal line length of camera image element}}$$

Note: Size of camera image element (V x H x Diagonal)
1/3 inch image element: 3.6x4.8x6.0 mm 1/2 inch image element: 4.8x6.4x8.0 mm
2/3 inch image element: 6.6x8.8x11.0 mm

9. DOF (Depth of Field)

Vertical distance in the specimen, measured from above and below the exact plane of focus, which still yields an acceptable image. The larger the N.A., the smaller the depth of field.

Eyepiece observation (Formula due to Berek)

$$\pm \text{DOF} (\mu m) = \frac{\omega \times 250.000}{N.A. \times M} + \frac{\lambda}{2 \times (N.A.)^2} \quad \lambda = \text{Standard wavelength (550 nm)}$$

ω: Resolution of human eye (Visual angle: 5 minute)
M: Total magnification (Objective mag. x Eyepiece mag.)

TV monitor observation

$$\pm \text{DOF} (\mu m) = \frac{\lambda}{2 \times (N.A.)^2} \quad \lambda = \text{Standard wavelength (550 nm)}$$

10. Bright-Field Illumination and Dark-Field Illumination

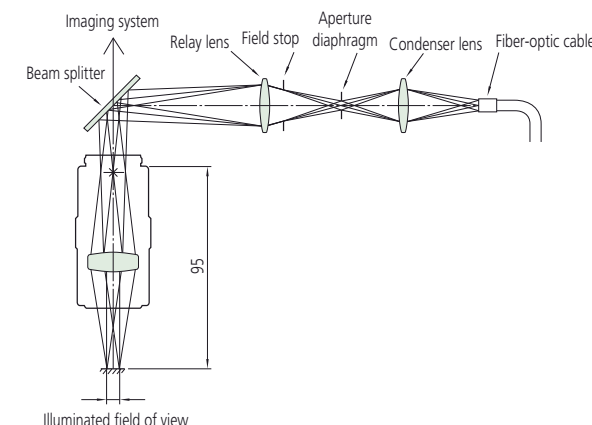
Bright-field illumination directly lights the specimen with a solid cone of rays and is the simplest method available. Dark-field illumination uses a hollow cone of rays formed by an opaque stop at the center of the condenser large enough to prevent direct light from entering the objective. The specimen is placed at the concentration of the light cone, and is seen with light scattered or diffracted by it, therefore scratches and dents on the specimen surface are illuminated while the rest remains dark.

11. Apochromatic Objective and Achromatic Objective

An apochromatic objective is corrected for chromatic aberration at the red, green and blue wavelengths. An achromatic objective is corrected for chromatic aberration at the red and blue wavelengths only.

12. Koehler Illumination

Köhler illumination overcomes the disadvantages of other schemes by causing parallel rays to light the specimen so that, because they will not be in focus, the image of the specimen will not include an image of the light source.



13. Telecentric Illumination

This illuminating optical system is designed so that principal light passes through the focal point. This system has the advantage of retaining the size of the image center even if it is out of focus (although the circumference of the image is defocused). This illumination system provides an even illumination intensity over the entire field of view.

14. Aperture Diaphragm

This diaphragm adjusts the amount of light passing through and is related to the brightness and resolving power of an optical system. This diaphragm is especially useful in width dimension measurement of cylindrical objects with contour illumination, and provides the highest degree of correct measurement/observation by suppressing diffraction in an optimal aperture.

15. Field Stop

This diaphragm is used for blocking out unwanted light and thereby preventing it from degrading the image.

16. Plan

Denotes an objective lens that produces a flat (planar) image by correcting the spherical aberration/curvature of the field of an achromatic lens or an apochromatic lens. All Mitutoyo FS series objectives are plan apochromat.

17. Vignetting

This unwanted effect is the reduction of an image's brightness or saturation at the periphery compared to the image center. May be caused by external (lens hood) or internal features (dimensions of a multi-element lens).

18. Flare

Lens flare is typically seen as several starbursts, rings, or circles in a row across the image or view, caused by unwanted image formation mechanisms, such as internal reflection and scattering of light.

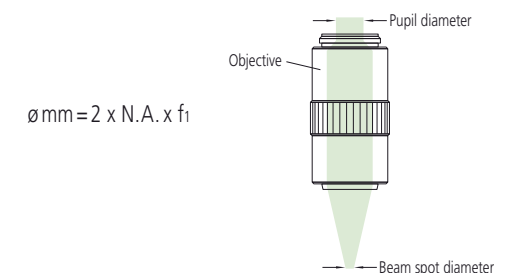
19. Double Image

An image degrading a phenomenon in which an image appears as if it is a double image due to redundant light projection and optical interference within the optical system.

20. Pupil Diameter and Spot Diameter of an Objective

• Pupil diameter

Denotes the maximum diameter of a parallel light flux along the optical axis that can enter an objective from the rear. The pupil diameter is calculated according to the following expression.



• Spot diameter

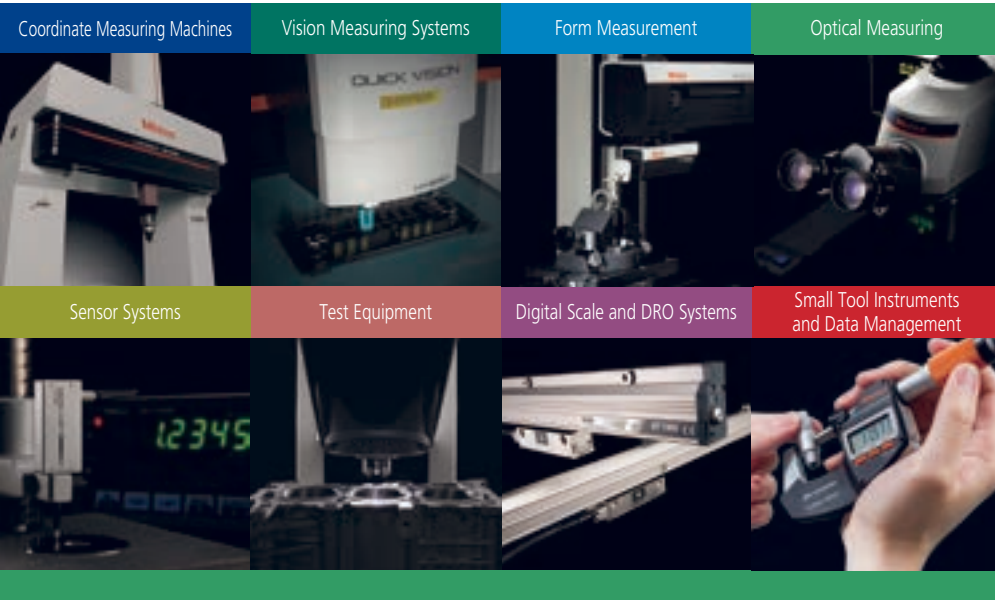
If a beam of light with a uniformly distributed intensity enters an objective from the rear, the beam is focused to a spot of finite size. This size is known as the spot diameter. The approximate value of a spot diameter is calculated from the following expression.

$$\phi \mu m = 1.22 \times \frac{\lambda}{N.A.}$$

However, the above expression cannot be applied if the light source is a laser beam of which the intensity forms a Gaussian distribution on the cross section. The diameter of a laser beam is generally indicated by 1/e² of the peak value, i.e. 13.5% of the peak value. The spot diameter of a laser beam is calculated from the following expression.

$$\phi \mu m = \frac{4 \times \lambda \times f}{\pi \times D}$$

(where λ is in μm; f and D are in mm)



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